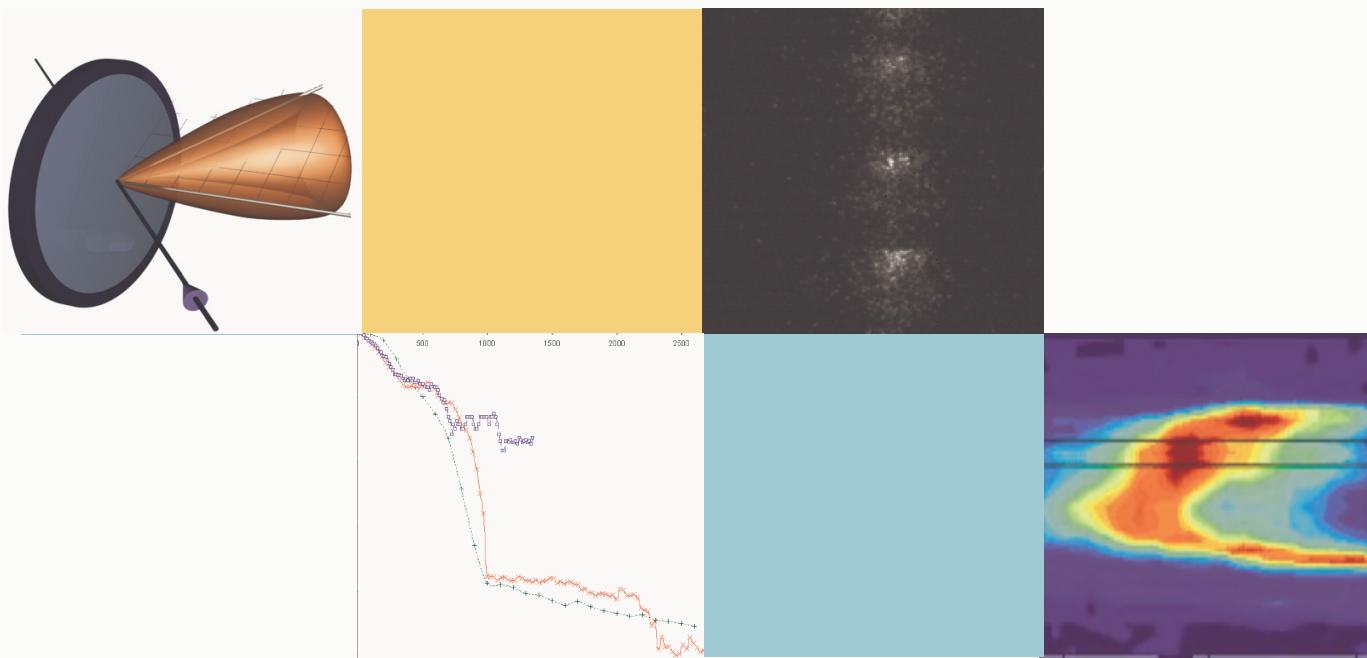


# Beam Profile Measurements @ CTF3

## *Past, Present and Future*



Carsten P. Welsch  
AB/BI/PM





# Outline



## 1. Transverse Beam Profiles

- General considerations
- OTR and SR as base for measurements
- Layout of the optical system (*optics, material choice, camera,...*)
- MTVs and Spectrometer Monitors (*Past, Present, Future*)
- Beam Halo Measurements
- Limitations

## 2. Longitudinal Beam Profiles

- Why do we care ?
- How to do the measurement ?
- Layout of long optical lines
- Results and Limitations
- Future Installations

## 3. Time-resolved Energy Measurements

- How to do the measurement ?
- SEM Grid
- Segmented photomultiplier
- Segmented Dump

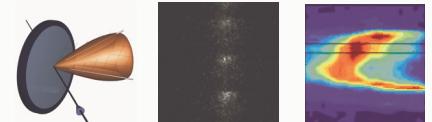
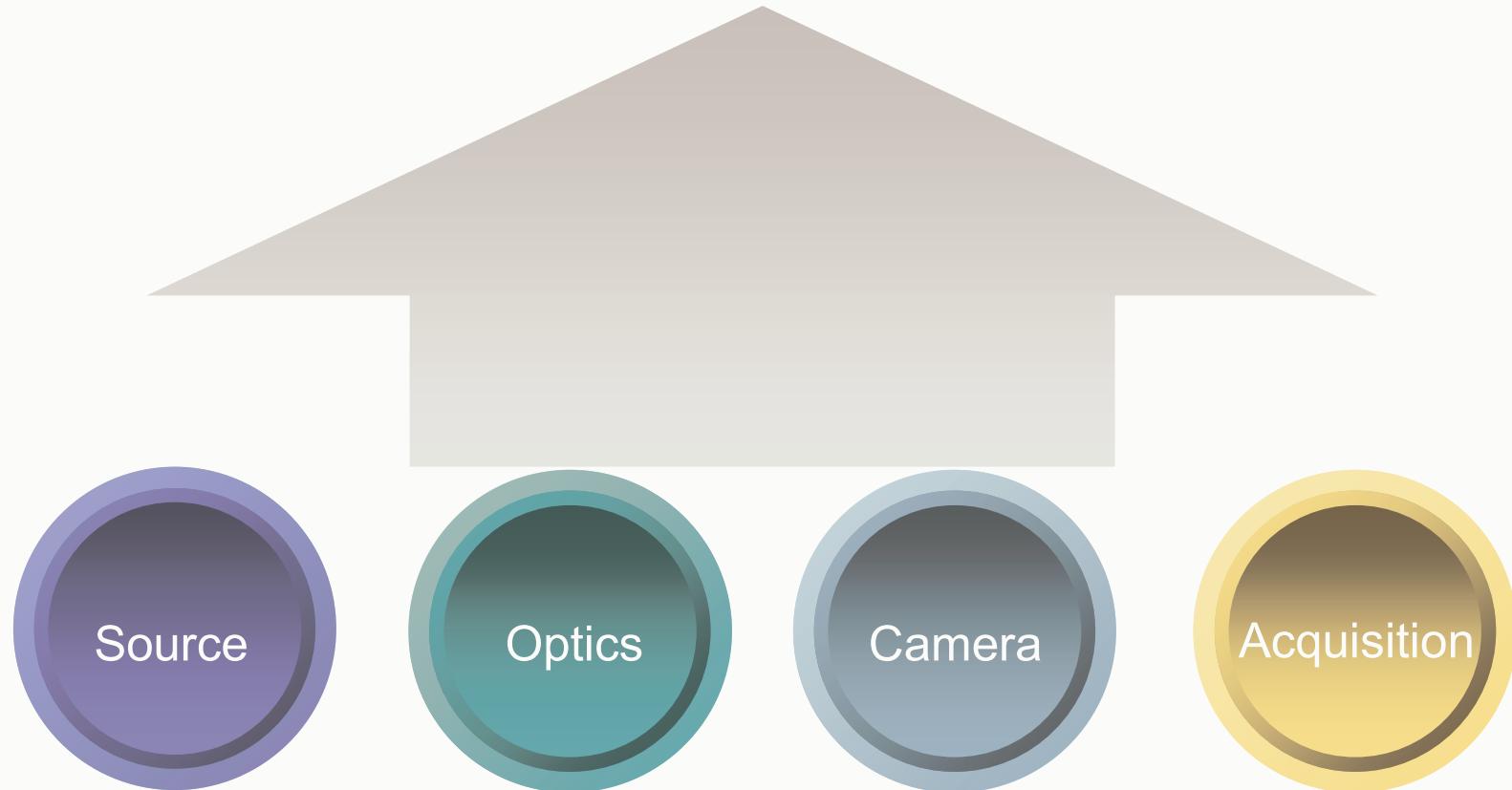




# Defining the Image Quality

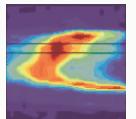
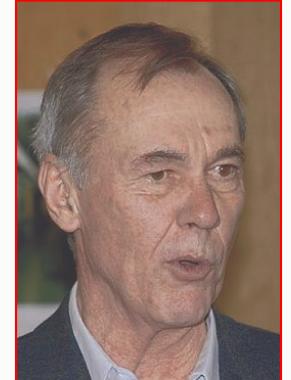
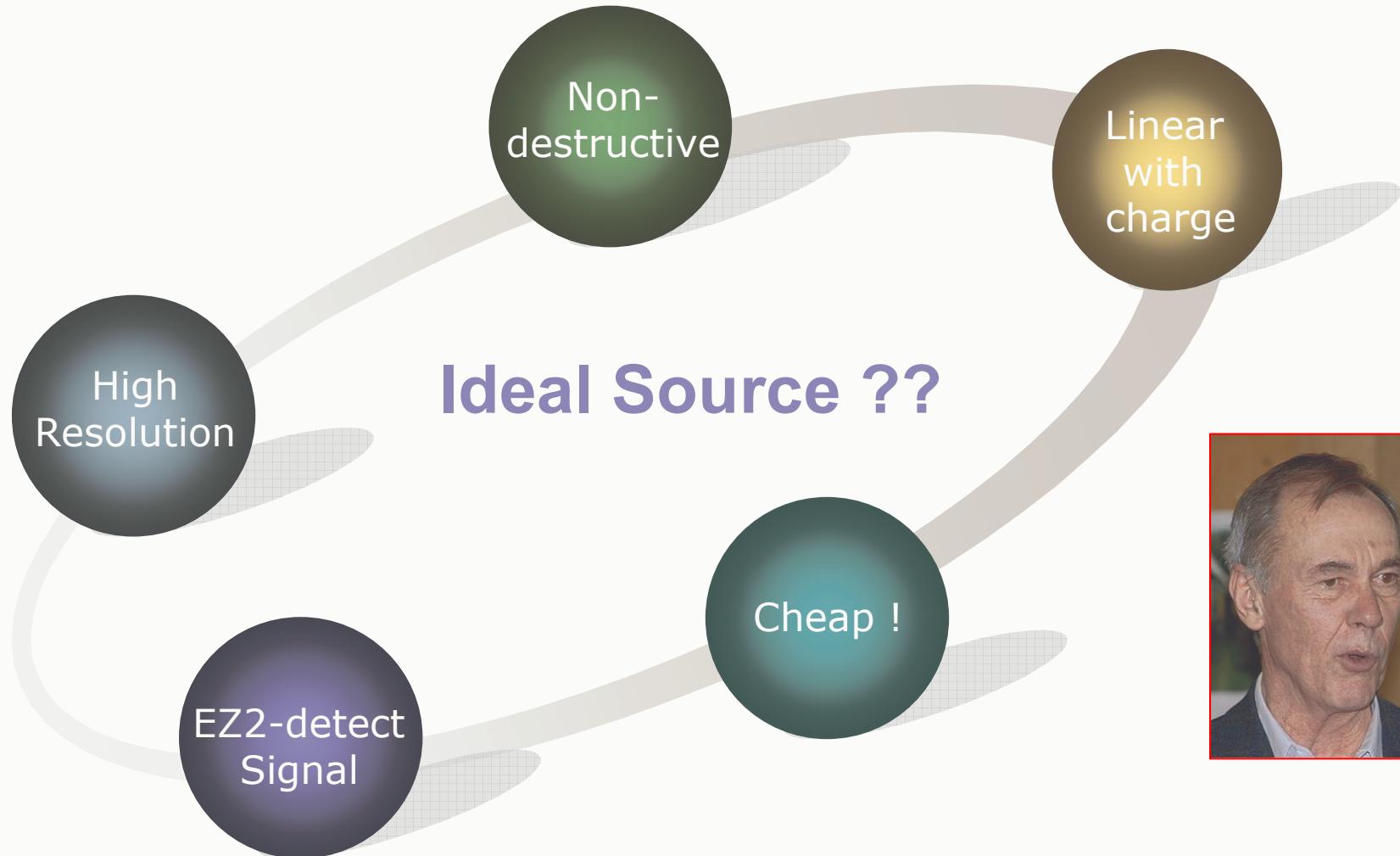


## Final Image



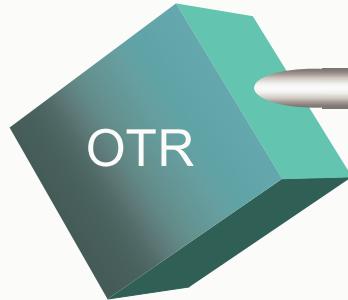


# The Magic of So(u)rcery





# A Brief (*incomplete*) Comparison



- Screen choice
- Linear, directive Signal
- Fast time response
- Add. Info ( $E, x', y', \dots$ )



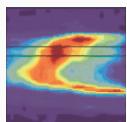
- Destructive
- Installation/Maintenance



- Non-destructive
- Highly directive
- Good signal if  $E \sim 150$  MeV



- Only in bends or chicane
- Alignment of line





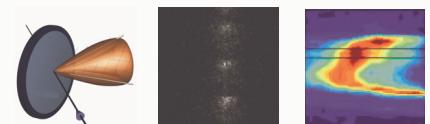
# CTF3 Diagnostic Requirements



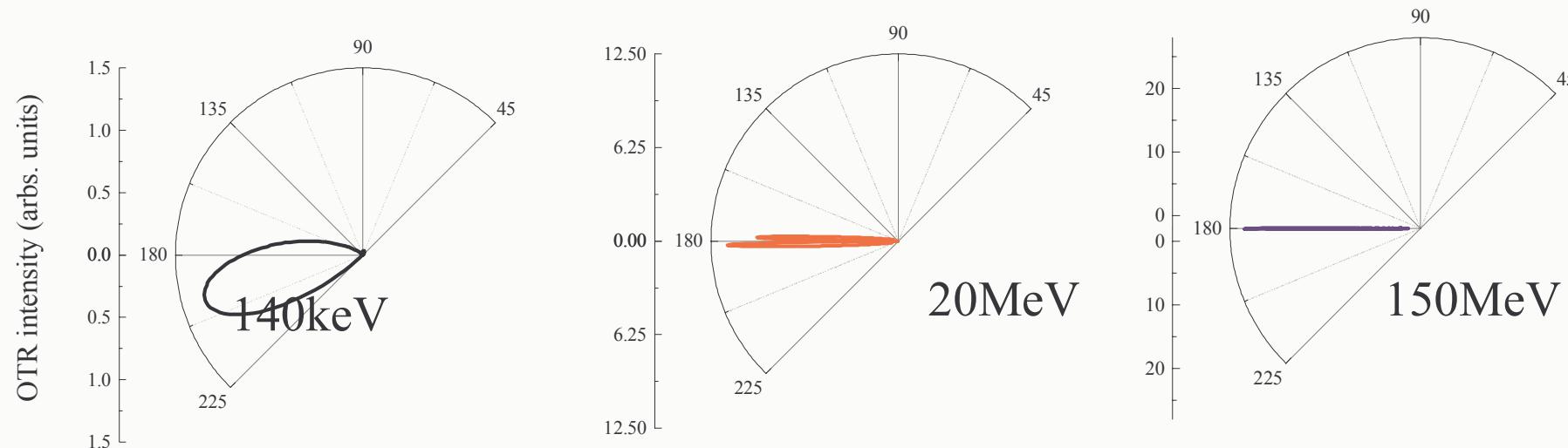
MTV's	Beam energy (MeV)	Beam charge (nC)	Beam size (mm)	Screen size (mm)	Spatial resolution (mm/pixel)
CL.MTV0165	0.140	10-7500 <sup>+</sup>	>1	> Ø 50	0.2
CLS.MTV0440	20	7.5-5600*	>1	100x50	0.25
CL.MTV0500	20	-	>0.8	> Ø 30	0.1
CL.MTV1030	70	-	>0.4	> Ø 30	0.1
CLS.MTV1050	70	-	>1	100x50	0.25
CL.MTV0435	150	-	>0.15	> Ø 30	0.1
CLS.MTV0455	150	-	>1	100x50	0.25

<sup>+</sup> Assuming commissioning conditions @100mA,100ns and nominal conditions @3.5A,1.56ms

\* Assuming 25% beam loss in the 3GHz bunching mechanism

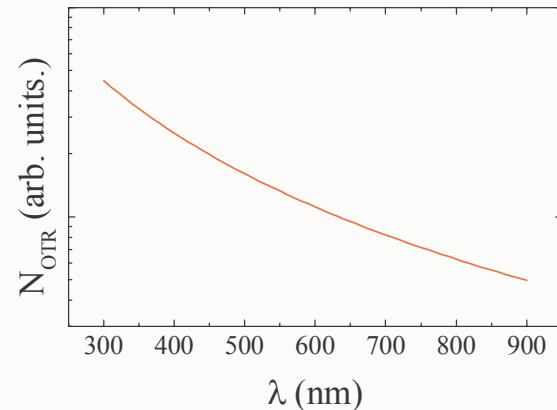


# Electron – Photon Conversion



Number of OTR photons/electron in wavelength range  $[\lambda_a, \lambda_b]$   
*(Ideal metallic surface)*

$$N_{OTR} = \frac{2\alpha}{\pi} \left[ \left( \beta + \frac{1}{\beta} \right) \cdot \ln \left( \frac{1+\beta}{1-\beta} \right) - 2 \right] \ln \left( \frac{\lambda_b}{\lambda_a} \right)$$



Electrons energy (MeV)	0.14	20	40	150
[400,600]nm OTR photons / electron	$7.2 \cdot 10^{-4}$	$7.3 \cdot 10^{-3}$	$8.6 \cdot 10^{-3}$	$1.1 \cdot 10^{-2}$
[400,600]nm OTR photons on camera	$4 \cdot 10^8$	$6 \cdot 10^{10}$	$7 \cdot 10^{10}$	$9 \cdot 10^{10}$



# Thermal Analysis: Material Study



$$\frac{\Delta T(r,t)}{\Delta t} = \frac{1}{c_p \rho} \left[ \frac{dE}{dx} \rho e^{-\frac{r^2}{2\sigma^2}} N(t) - k \nabla^2 T(r,t) - \frac{2\epsilon\sigma_s}{\delta} (T(r,t)^4 - T_0^4) \right]$$

Heating term
Cooling terms

Target :  
 $\epsilon$  : Emissivity  
 $\delta$  : Thickness  
 $c_p$  : Specific heat  
 $\rho$  : Density  
 $k$  : Thermal conductivity

Electron beam :  
 $\sigma$  : beam size  
 $N(t)$  : beam current

Material	$c_p$ J/gK	$k$ W/mK	$T_{max}$ °C
Be	1.825	190	1287
C	0.7	140	3527
Al	0.9	235	660
Si	0.7	150	1414
Ti	0.523	22	1668
Mo	0.25	139	2623
W	0.13	170	3422

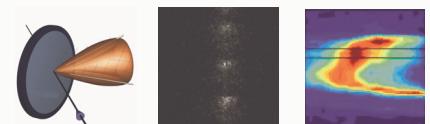


Thin foil of material with  

- High fusion temperature
- High specific heat  $c_p$
- High thermal conductivity

*(for graphite  $\Delta T=12\%$  after 1ms)*

E. Bravin, T. Lefevre



# Examples from CTF3

## Calculations for the injector profile monitor

<b>I = 5.4A , E = 140keV , <math>\sigma</math> = 1mm</b>					
$t_p$ ( $\mu$ s)	T ( $^{\circ}$ C) @ 10Hz		T ( $^{\circ}$ C) @ 50Hz		
	C	Al	C	Al	
0.2	103	83	164	132	
0.8	272	194	558	421	
1.56	440	434	1003	x	

## Calculations for the linac profile monitors

<b>I = 3.5A , E = 150MeV , <math>t_p</math> = 1.56<math>\mu</math>s</b>					
$\sigma$ (mm)	T ( $^{\circ}$ C) @ 10Hz		T ( $^{\circ}$ C) @ 50Hz		
	C	Al	C	Al	
0.25	1730	x	2250	x	
0.5	-	x	-	x	
0.6	-	510	-	650	

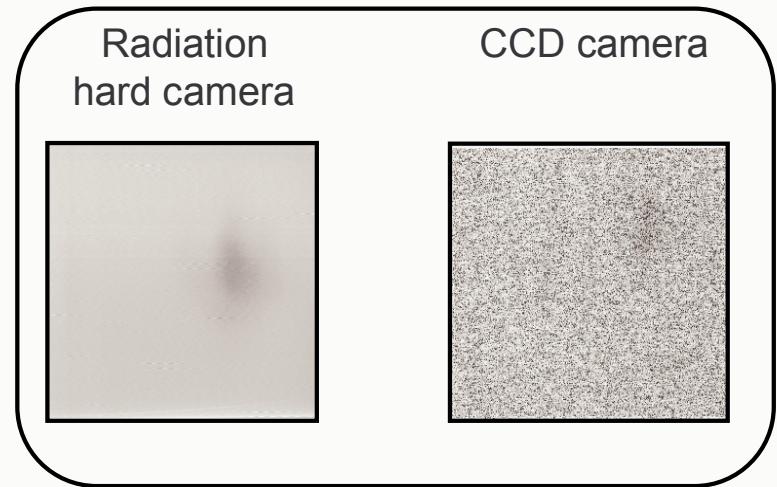
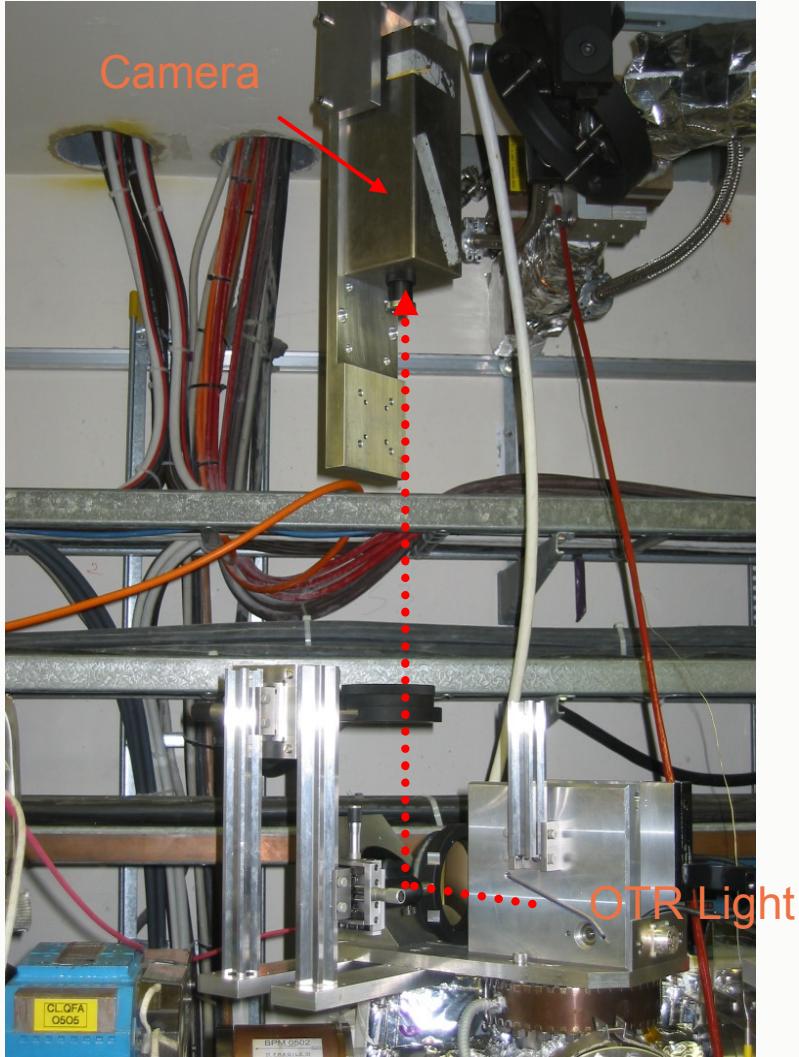
- Carbon screens stand the full beam intensity for the maximum repetition rate at every energy.
- Some alternatives for reduced bunch charge / lower repetition rate.

E. Bravin, T. Lefevre



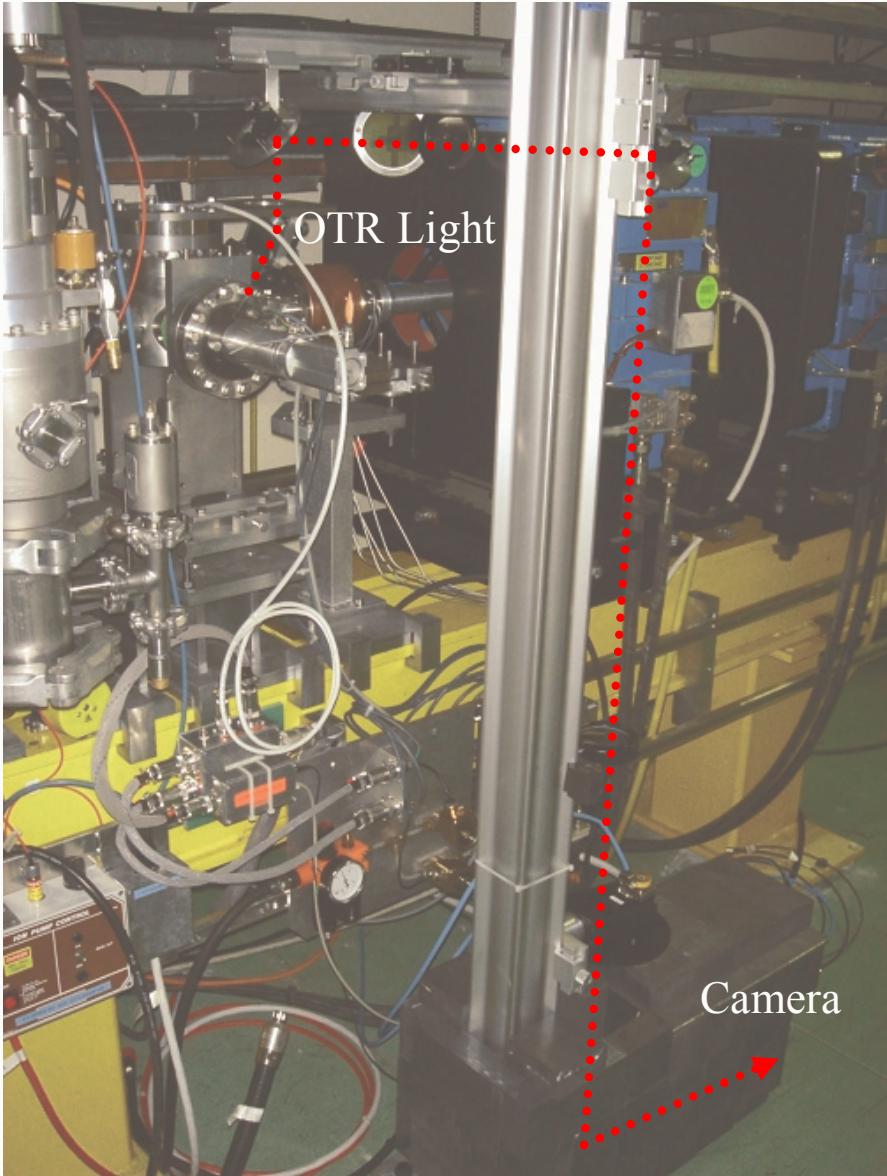


# Past Installations





# Present Layout



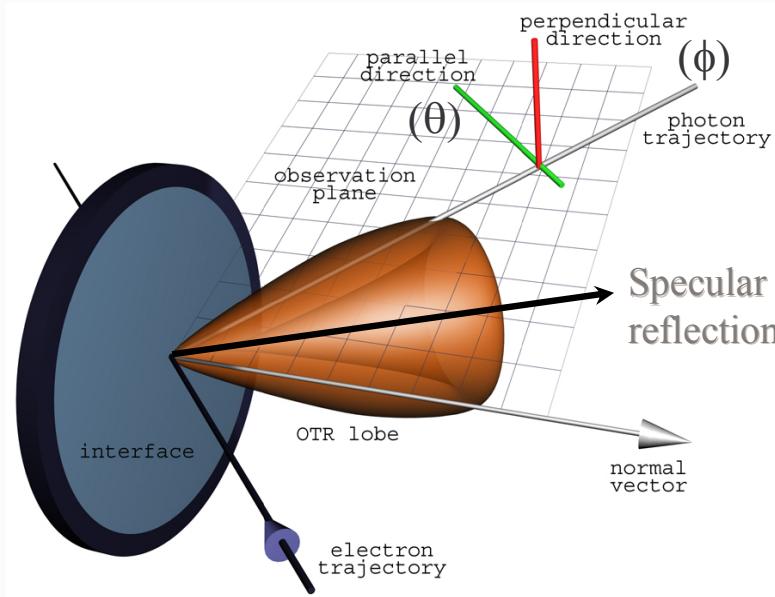
Design dominated by  
spatial constraints

Existing vacuum tanks used

Shielding of equipment



# Simulation of OTR in ZEMAX



$$\frac{d^2W}{d\Omega d\omega} = \frac{d^2W_{||}}{d\Omega d\omega} + \frac{d^2W}{d\Omega d\omega} \approx \frac{q^2}{\pi^2 c} \frac{\theta^2}{(\gamma^{-2} + \theta^2)^2}$$

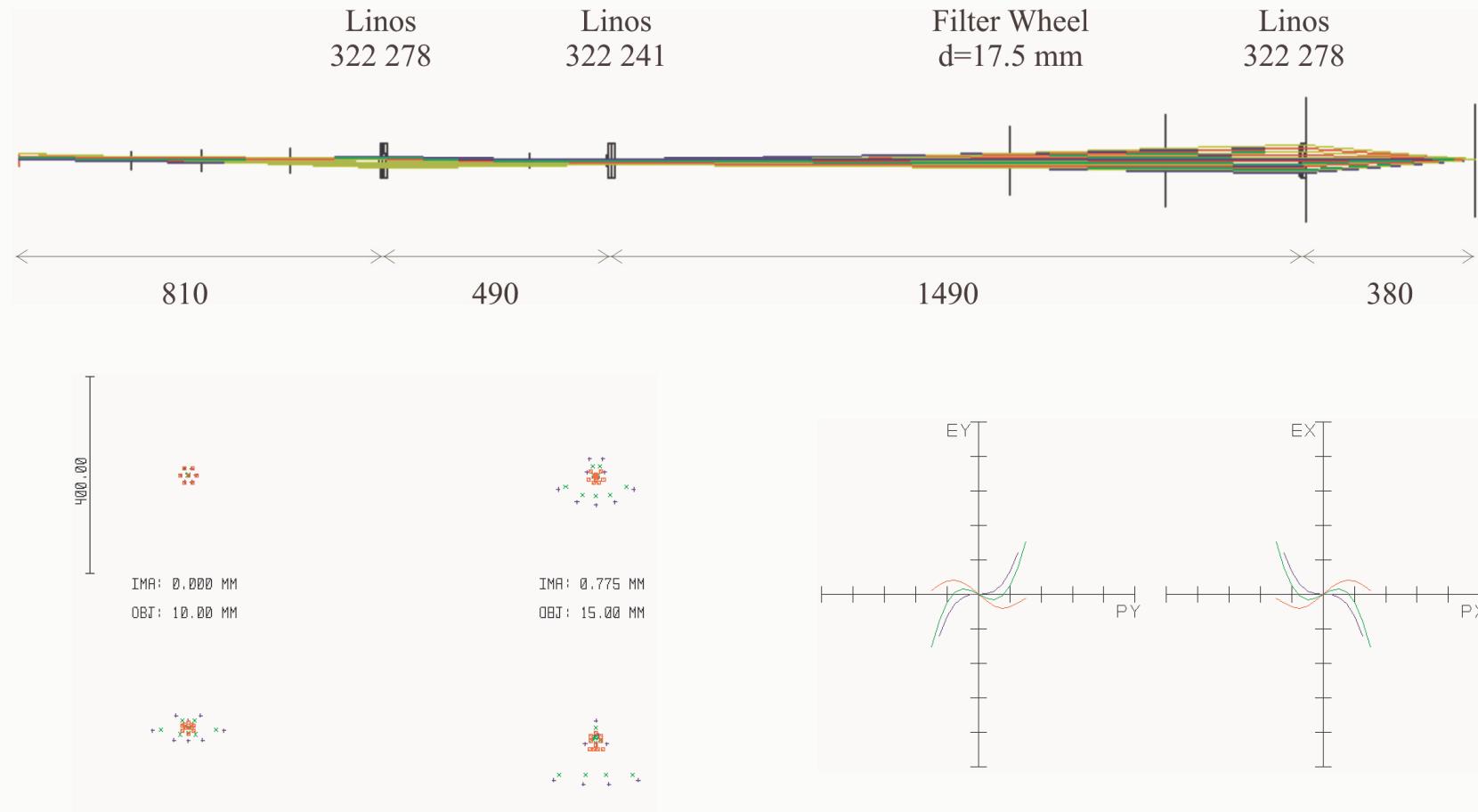
Maximum at  $\theta_{max} = 1/\gamma$  → Used in ZEMAX.

25 MeV	$2.29^\circ$
80 MeV	$0.73^\circ$
160 MeV	$0.36^\circ$





# Lens Configuration - ZEMAX



Spot diagram, max: 400μm

Ray aberrations, max: 400μm



# Installed Screens at CTF3



## Linac (Emittance)



### Backward OTR screens

- Two screens at  $20^\circ$  (*observation at  $40^\circ$* )
- $10\mu\text{m}$  thick Al-foil ( $\sim 90\%$  reflectivity)
- $100\mu\text{m}$  thick C/SiC foil ( $\sim 26\%$  reflectivity) (No)
- Active Size :  $\varnothing 5\text{cm}$



Scan in X



Scan in Y

## Spectrometer ( $E, \Delta E$ )

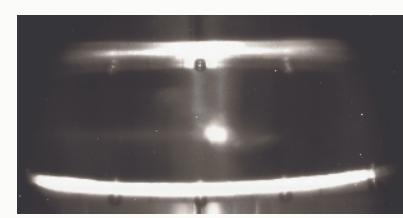


### Backward OTR screen

- Fixed screen tilted at  $45^\circ$  (*observation at  $90^\circ$* )
- $10\mu\text{m}$  thick Al-foil ( $\sim 90\%$  reflectivity)
- Active Size :  $10\text{cm} \times 5\text{cm}$



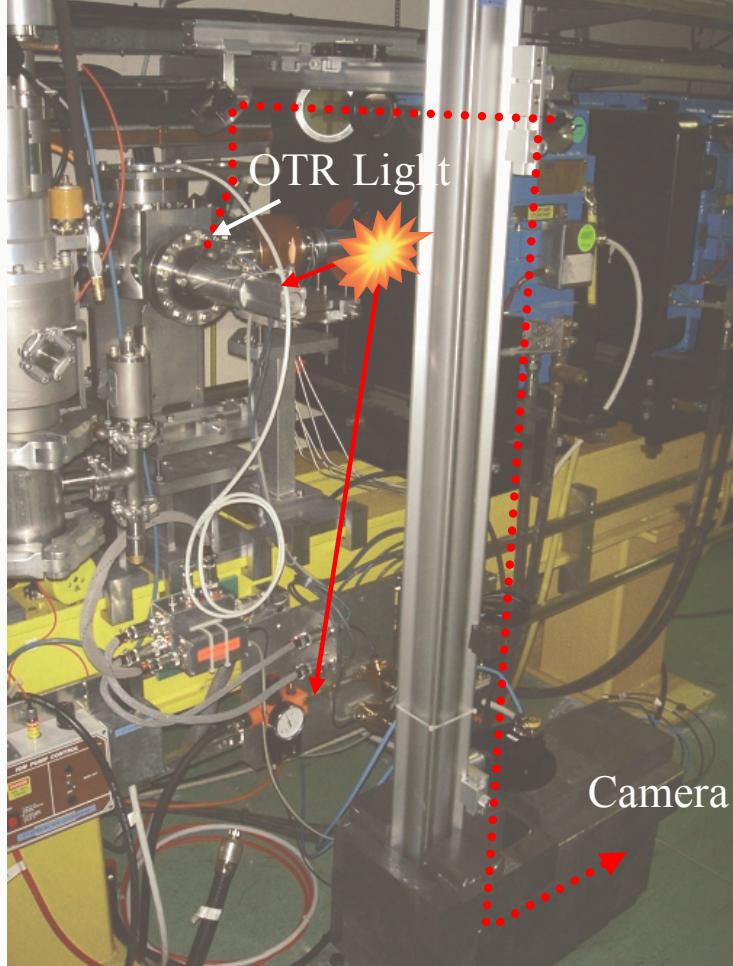
Light off



Light on



# Linac: Radiation Issues

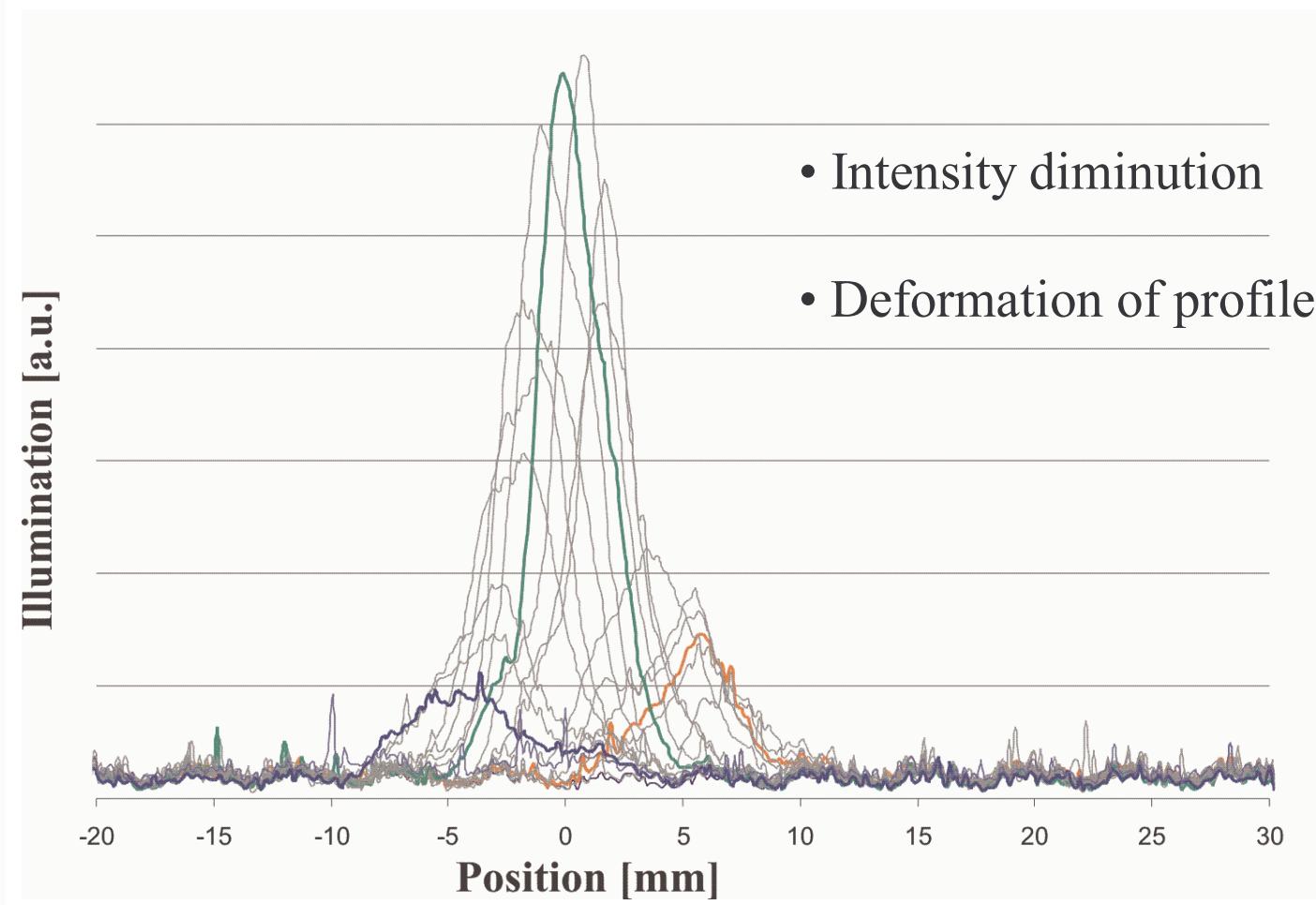


- CCD destroyed within weeks
  - Lens darkening
  - Damage to valves, cables and connectors
- New (modular) rad-hard layout.





# Problems in Spectrometer

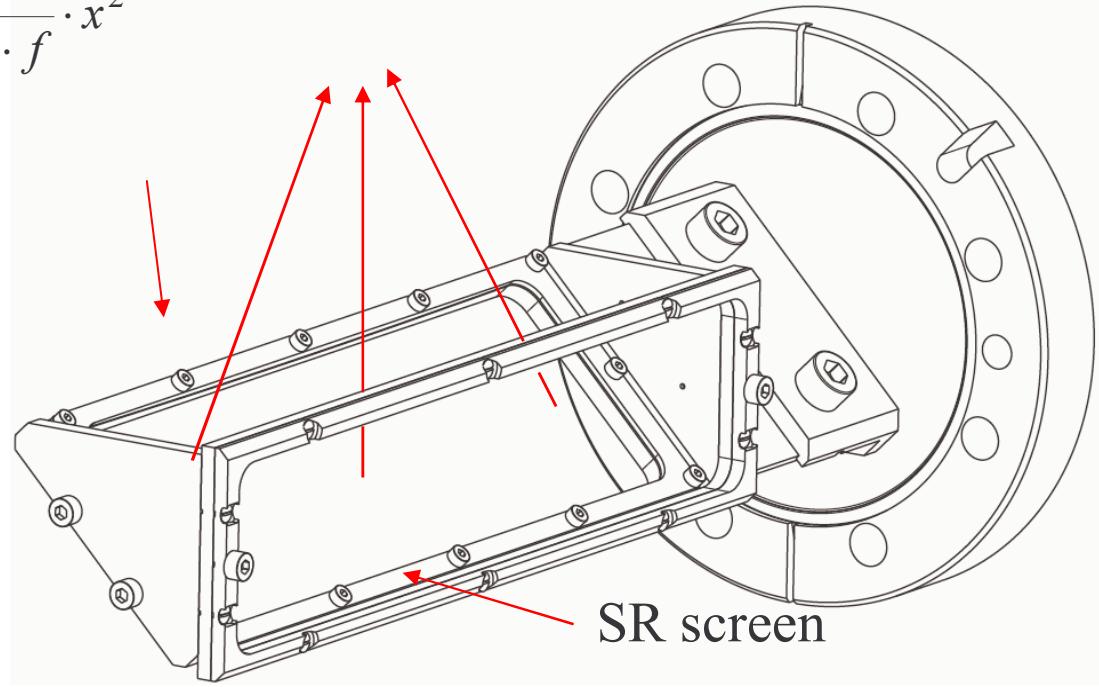




# Solution: Parabolic Screen



$$z = \frac{1}{4 \cdot f} \cdot x^2$$



Proc. EPAC 06

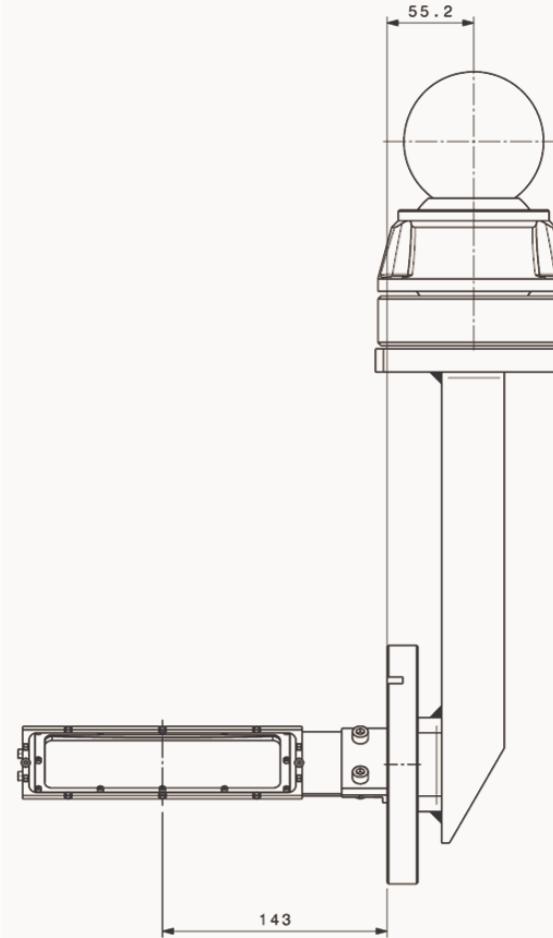
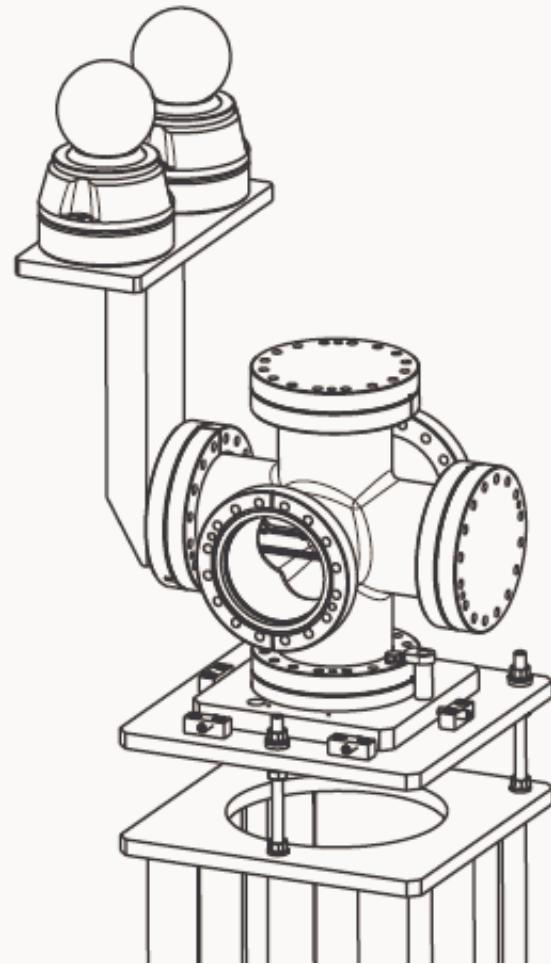


Standard for future installations.

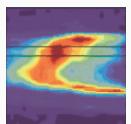




# Spectro Tank: New Layout



- Cheap, simple design,
- Screen can be aligned ex situ.

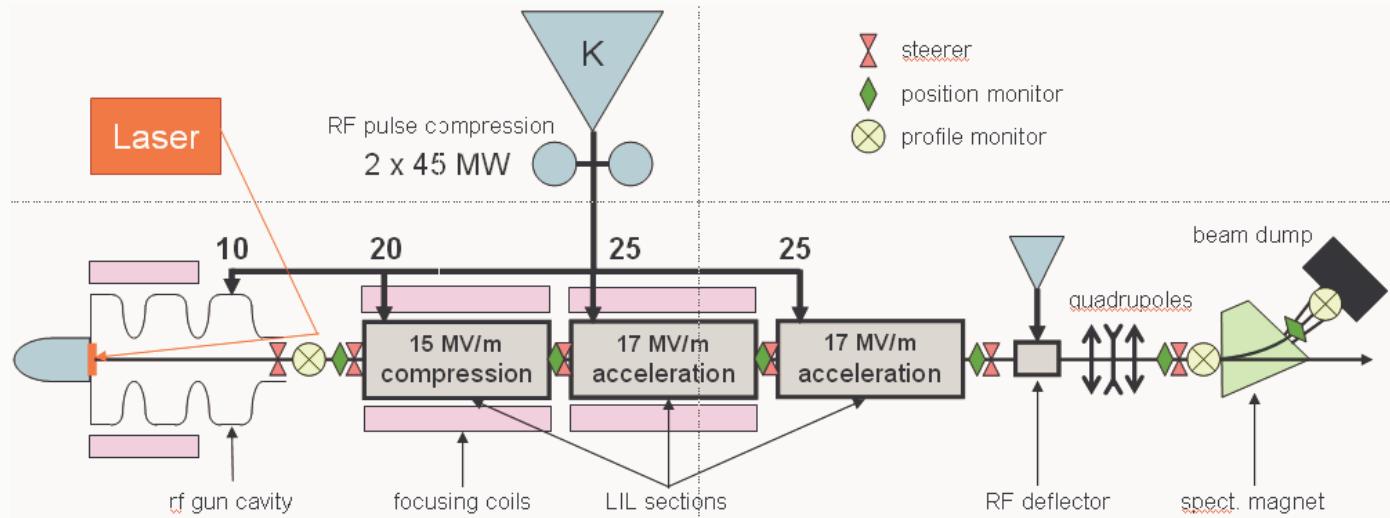


# CALIFES (guess !?)

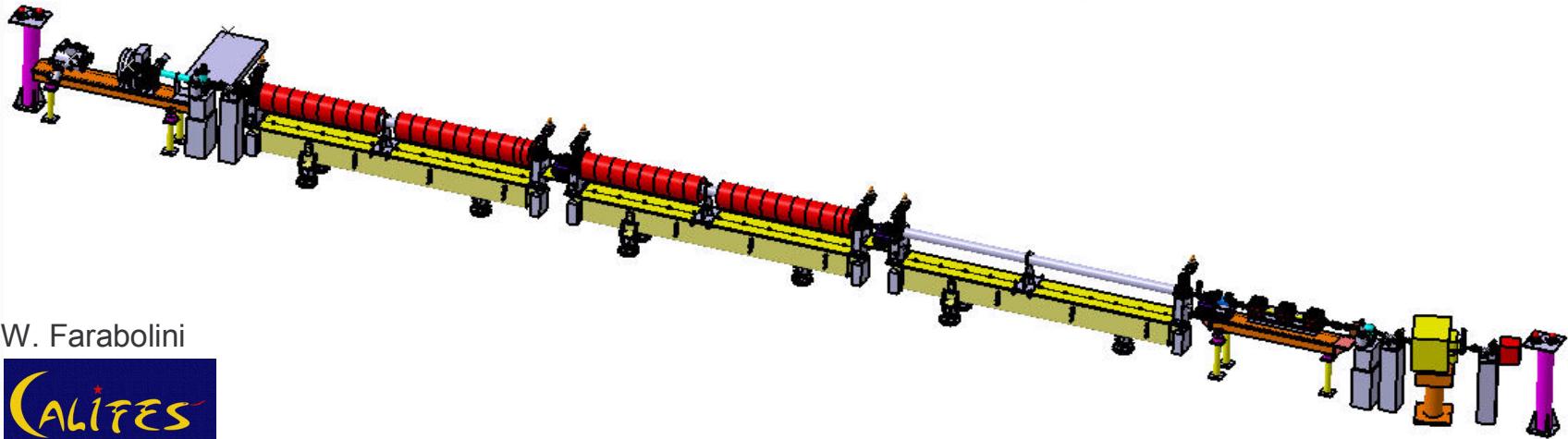


Energy	200 MeV
Emittance rms	$< 20 \pi$ mm.mrad
Energy spread	$< \pm 2\%$
Bunch charge	0.5 nC
Bunch spacing	0.333 ns
Number of bunches	1 – 64
Bunchlength	$< 0.75$ ps

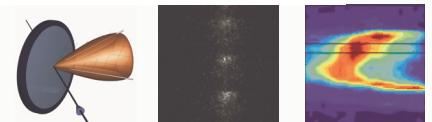
Concept d'Accélérateur Linéaire pour Faisceau d'Electrons Sonde



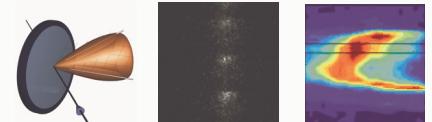
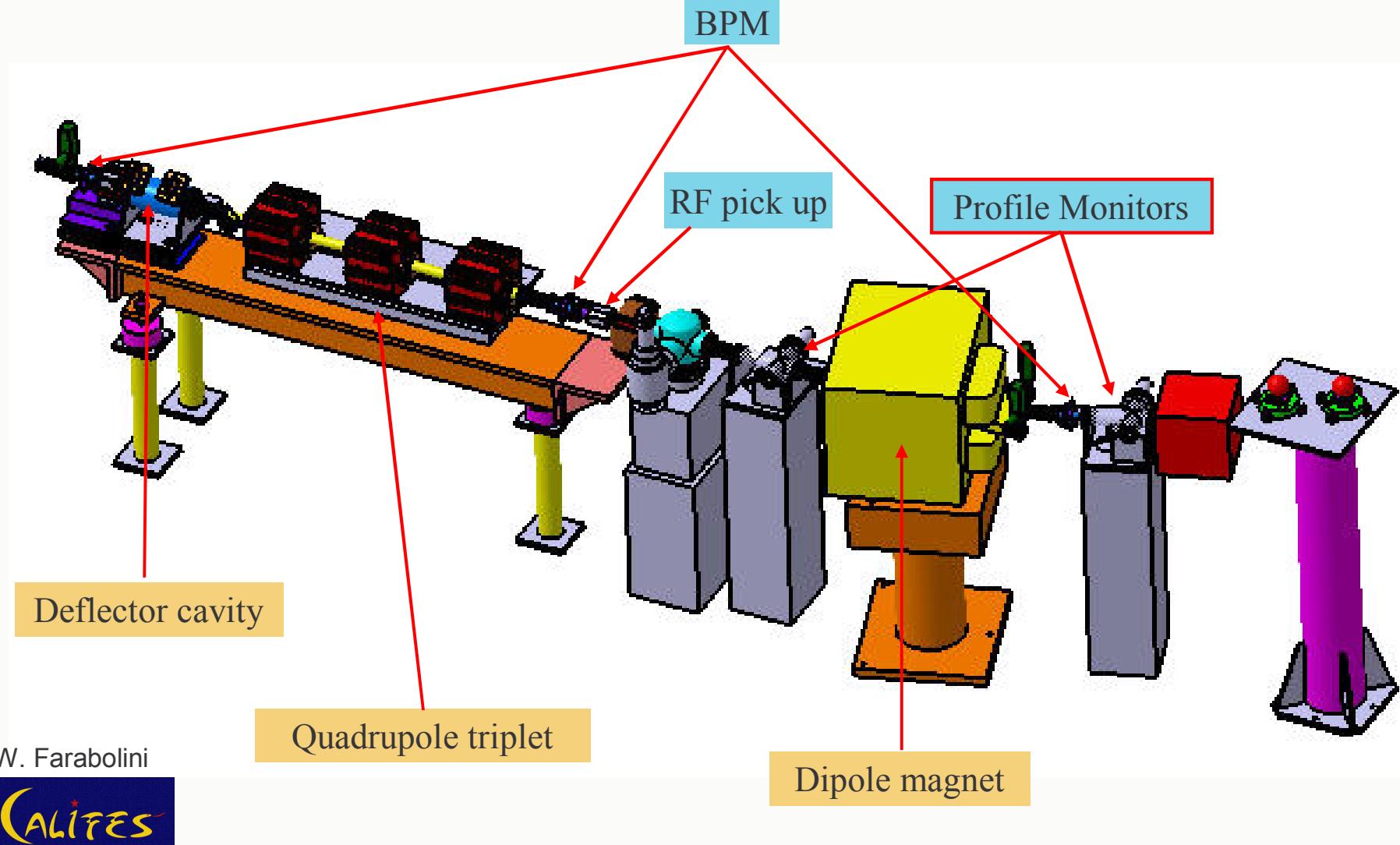
Schematic layout of the probe beam linac (CALIFES)



W. Farabolini



# Diagnostic Installations

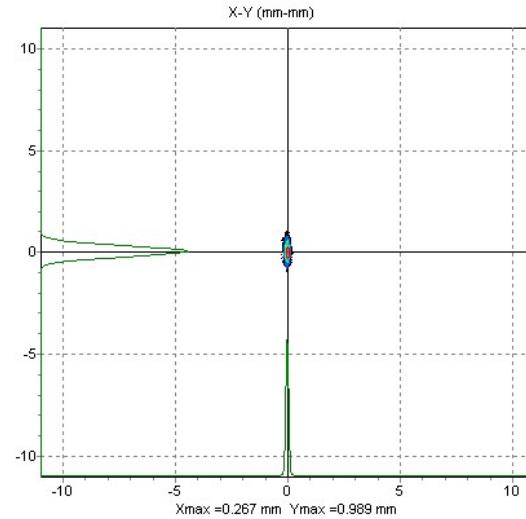




# Simulation of e<sup>-</sup> Beam Parameter

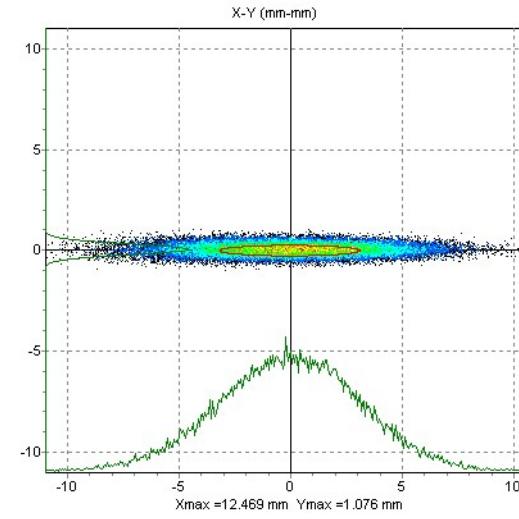


Ele: 13 [3.4143 m] NGOOD : 10000 / 10000 TraceWin - CEA/DSM/DAPNIA/SACM

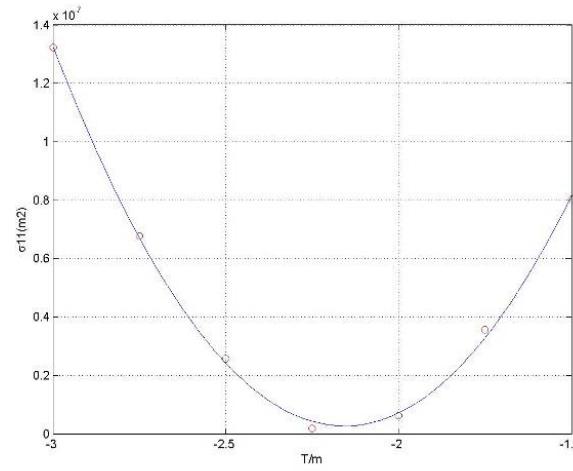


Quad scan simulation - Waist

Ele: 13 [3.4093 m] NGOOD : 40000 / 40000 TraceWin - CEA/DSM/DAPNIA/SACM



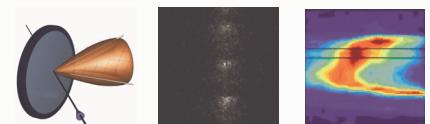
Spectrometer line



$$\sigma_{11} = \langle x^2 \rangle \text{ vs. Quad gradient}$$

Intensity between  $10^8$  -  $10^{11}$  e<sup>-</sup>  
Spot between 0.01 et some mm<sup>2</sup>

W. Farabolini





# Different Characteristics

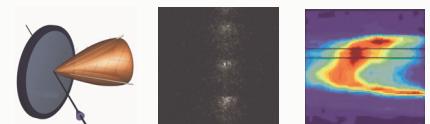


CCD camera 1/3'' (4.8 x 3.6 mm<sup>2</sup>)

Frame grabber 416 x 312 pixels (pixels of 11.5 μm)

Position	After canon	After triplet	After Dipole
Aim	Check beam position and dimensions	Emittance measurement	Energy dispersion measurement
Specifications	None	Resolution $\leq 20 \mu\text{m}$ size 10 x 10 mm <sup>2</sup>	Resolution $\Delta p/p \leq 1\%$ Precision < 2% of nominal energy
Energy	5 MeV	177-200 MeV	177-200 MeV
Beam size	2-3 mm rms	50 μm (waist) – 3 mm	20 x 0.5 mm
Magnification	0.2	1.73 <u>and</u> 0.36	0.18
Screen type	Phosphor or YAG	OTR and Phosphor	Phosphor
Resolution pattern	Engraved on screen	Movable or on dedicated optical line	Engraved on screen

W. Farabolini





# How to Decide for a Screen...



## Phosphor or Chromox

- Powder deposition ( $\text{Y}_2\text{SiO}_5:\text{Ce}, \text{Tb}$ ) on substrate or Al+Ce,
- Omni directional emission,
- High gain (*P47: 630 ph/e<sup>-</sup> @ 15 keV*)
- Monochromatic spectrum,
- Saturation and non-linear,
- Can be damaged if  $> 1 \text{ C/cm}^2$ ,
- Remanence ( $0.1 \mu\text{s} - \text{some ms}$ ),
- Spatial resolution is function of thickness.

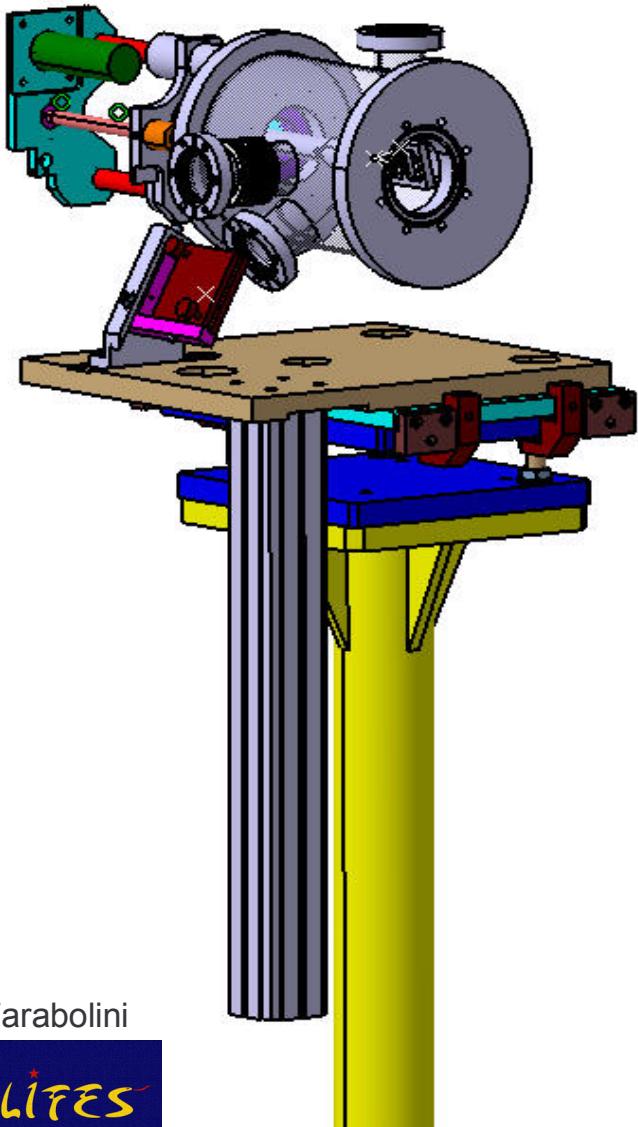
## OTR

- Thin foil of Al, C, Si, SiC,...
- Narrow emission angle ( $2/\gamma$ ),
- Weak gain (*0.015 ph/e<sup>-</sup> @ 200 MeV*)
- Large spectrum,
- Very robust (see: thermal effects),
- No remanence,
- Very good spatial resolution.

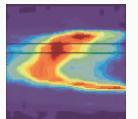
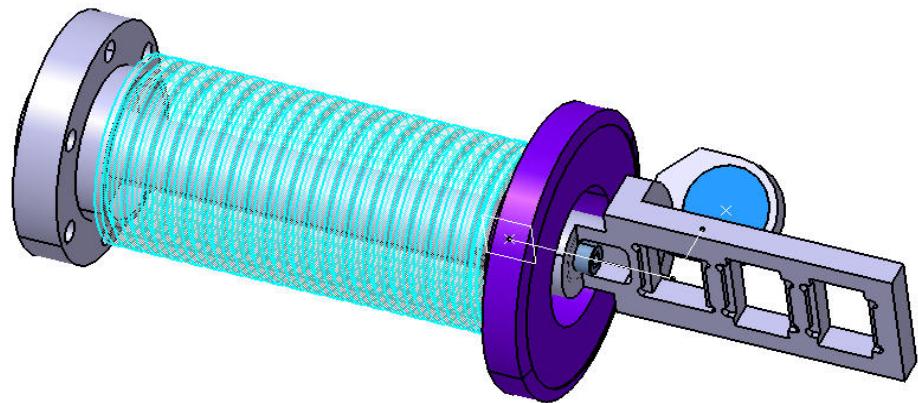
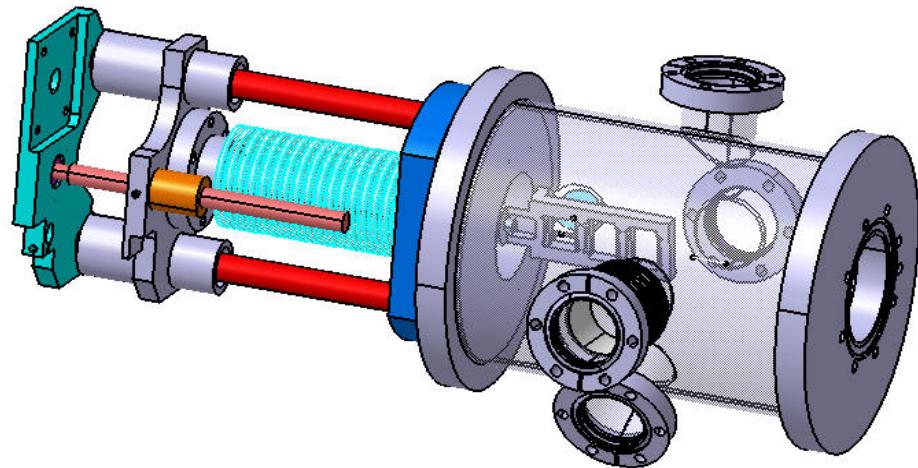




# New Chamber Layout

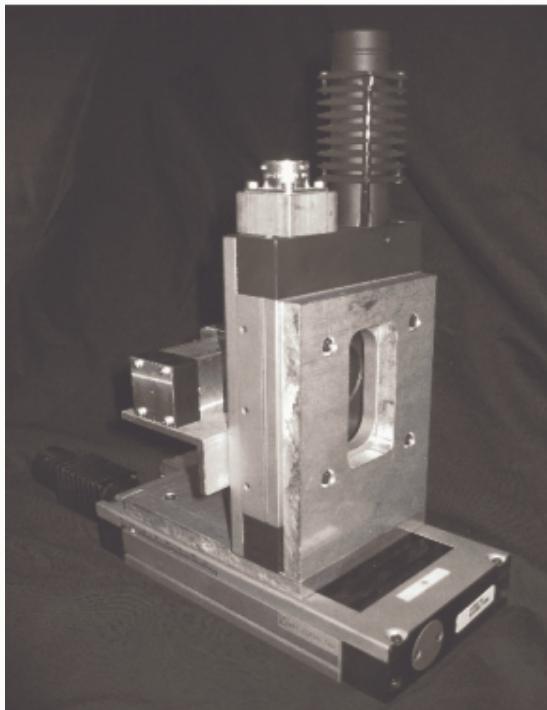


W. Farabolini





# Halo Monitor



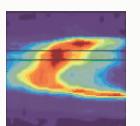
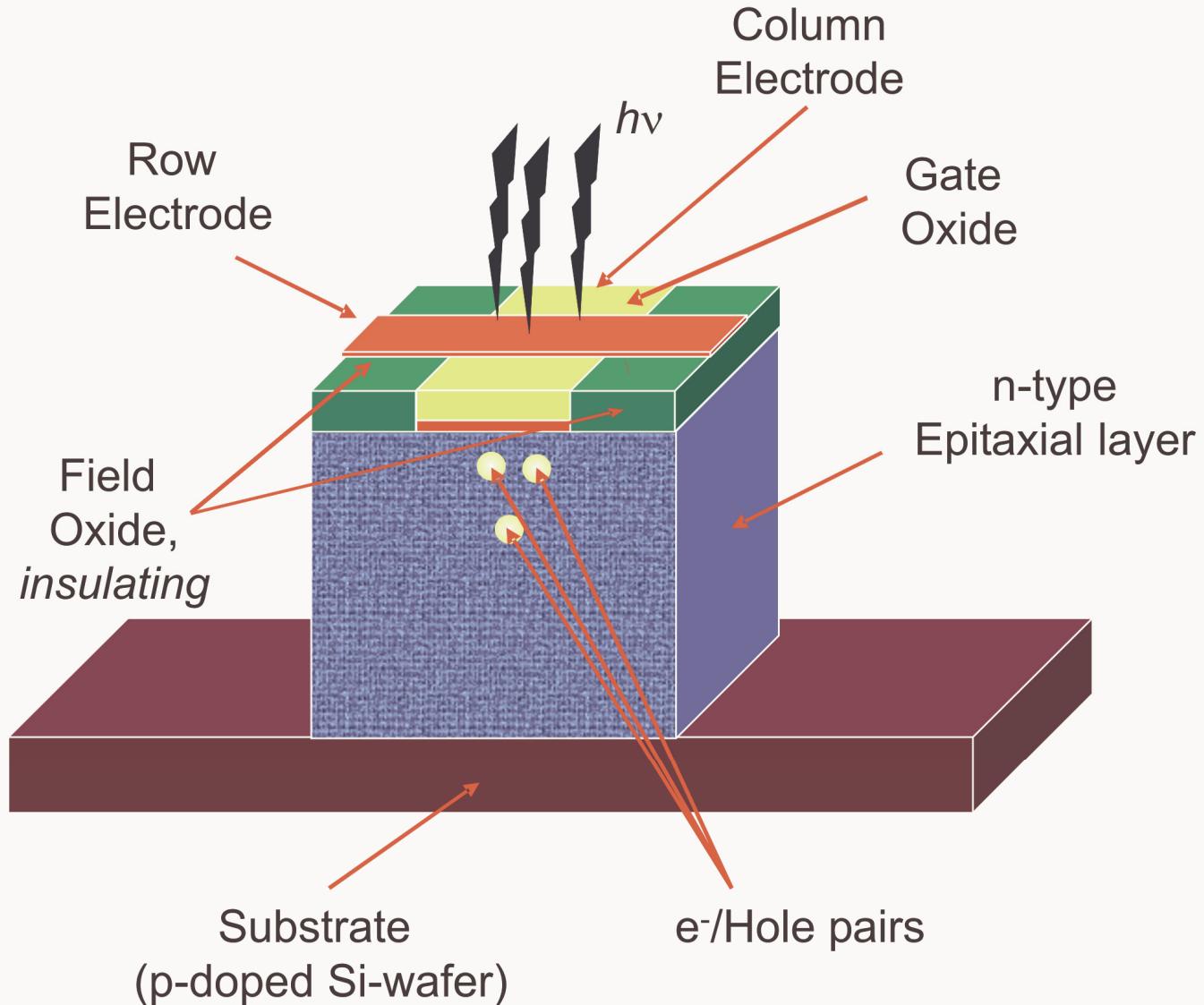
## Under investigation:

- 2D PMT setup
- SpectraCAM CID camera
- Micro Mirror Array

Meas. Sci. Technol. 17 (2006) 2035–2040

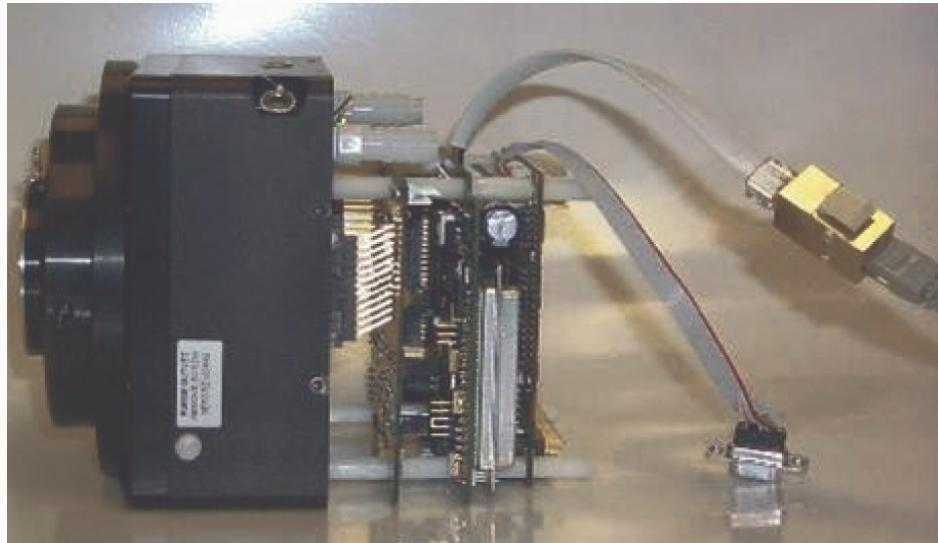


# CID Technology





# SpectraCAM System



Sealed camera head including read-out electronics

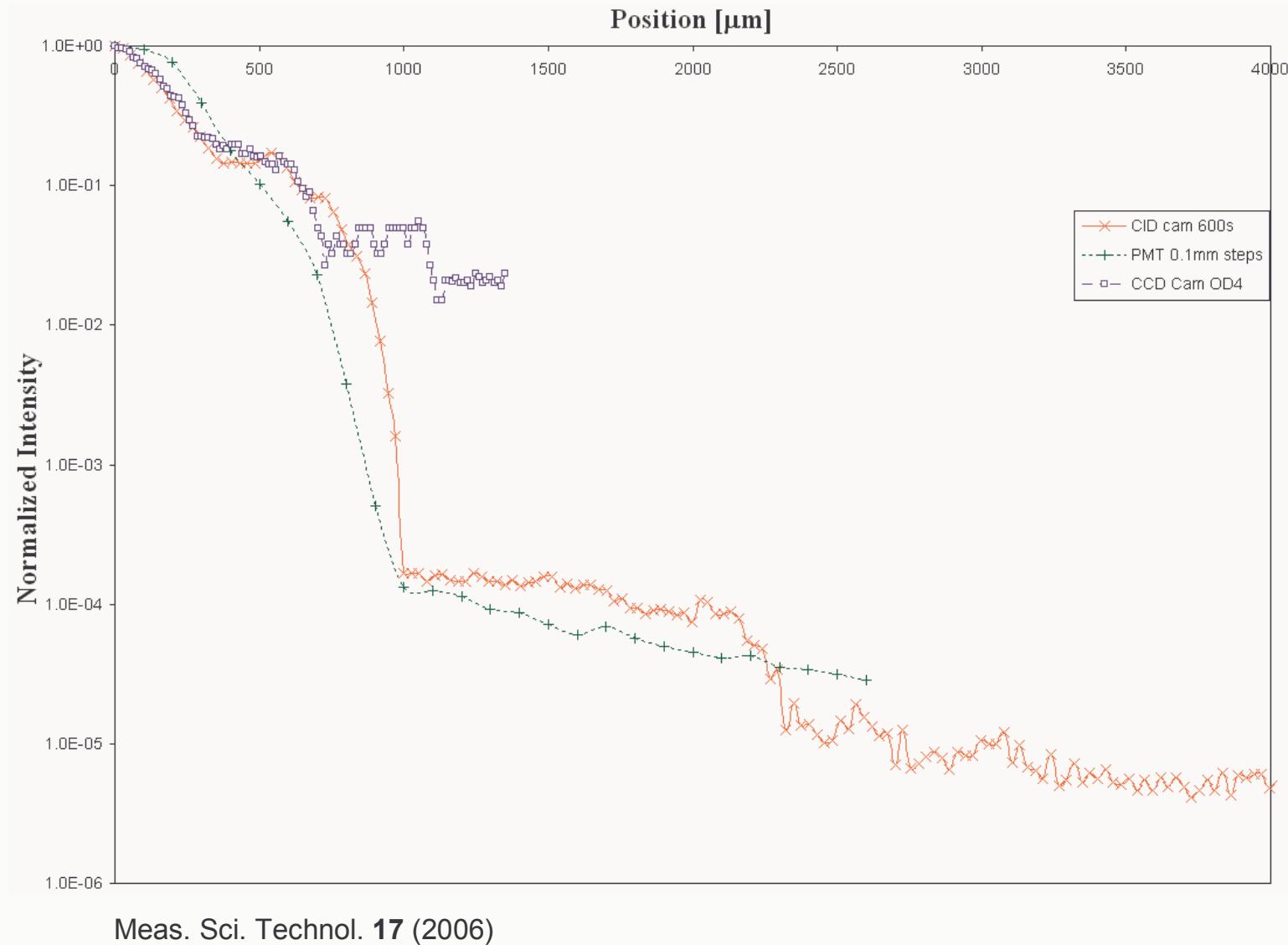


Water cooling system and integration electronics

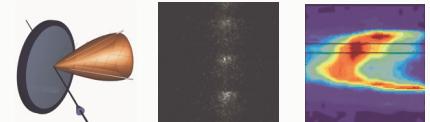




# Halo Measurements

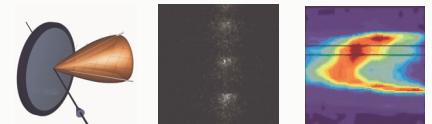
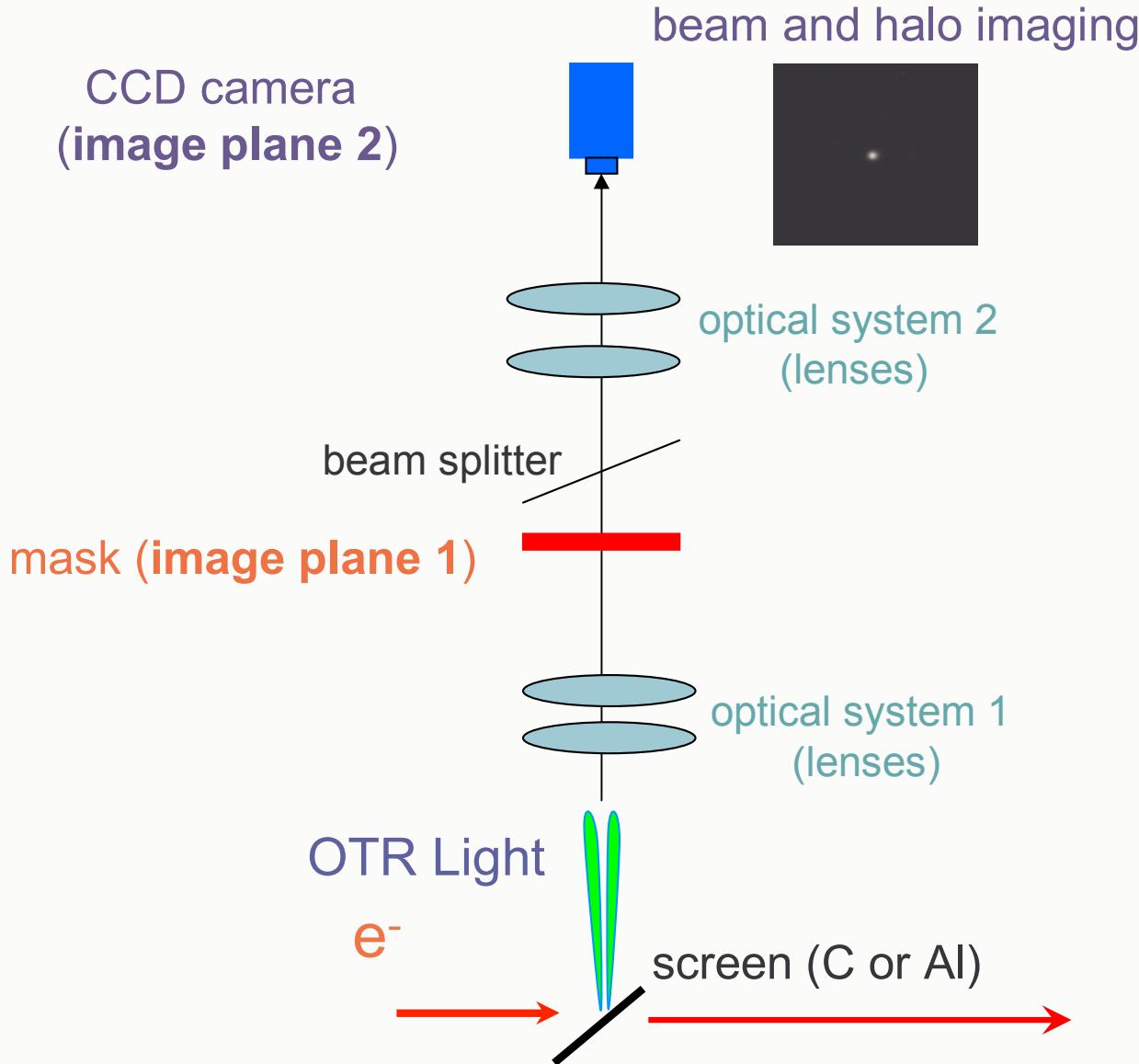


Meas. Sci. Technol. 17 (2006)





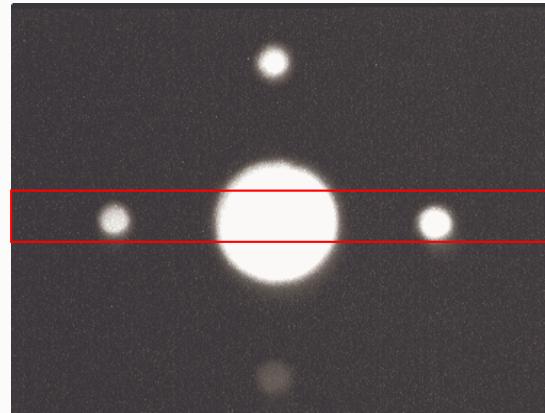
# Core Masking Technique



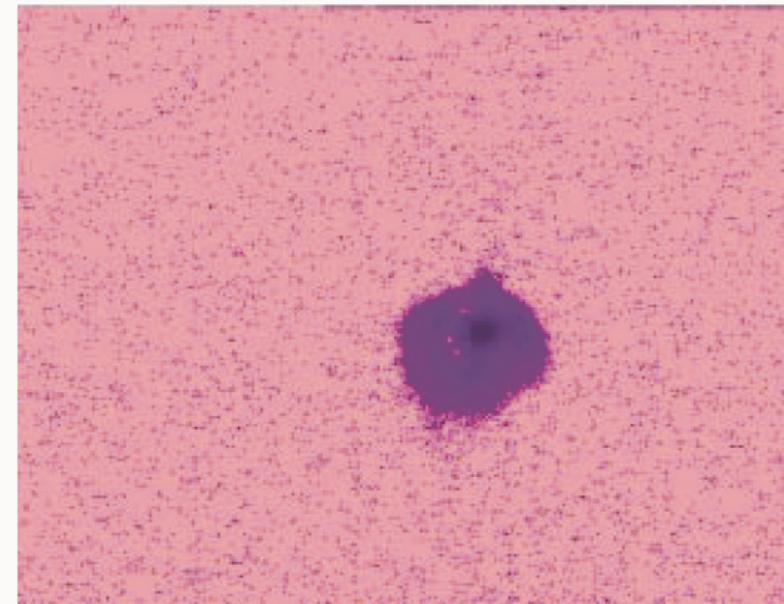


# Calibration: Opacity

Phantom image without mask

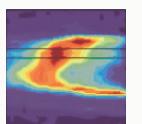


Phantom image with mask



Factor 100  
higher dynamic range.

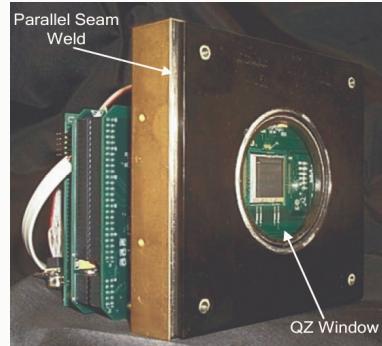
Proc. EPAC04





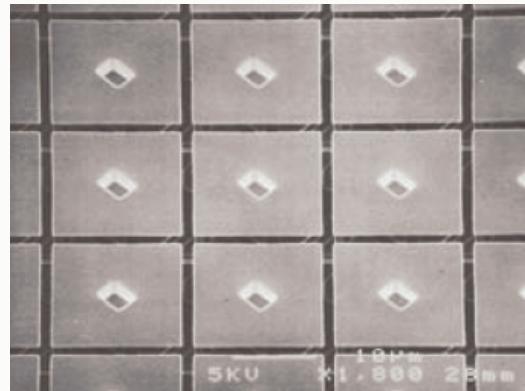
# Future Perspectives

## 1. SpectraCAM XDR from Thermo



2048<sup>2</sup> pixels

## 2. Micro Mirror Array from Vialux



1024 x 768 pixels (XGA)

USB Interface

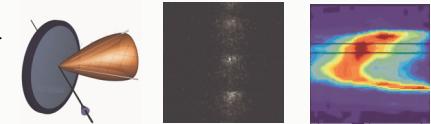
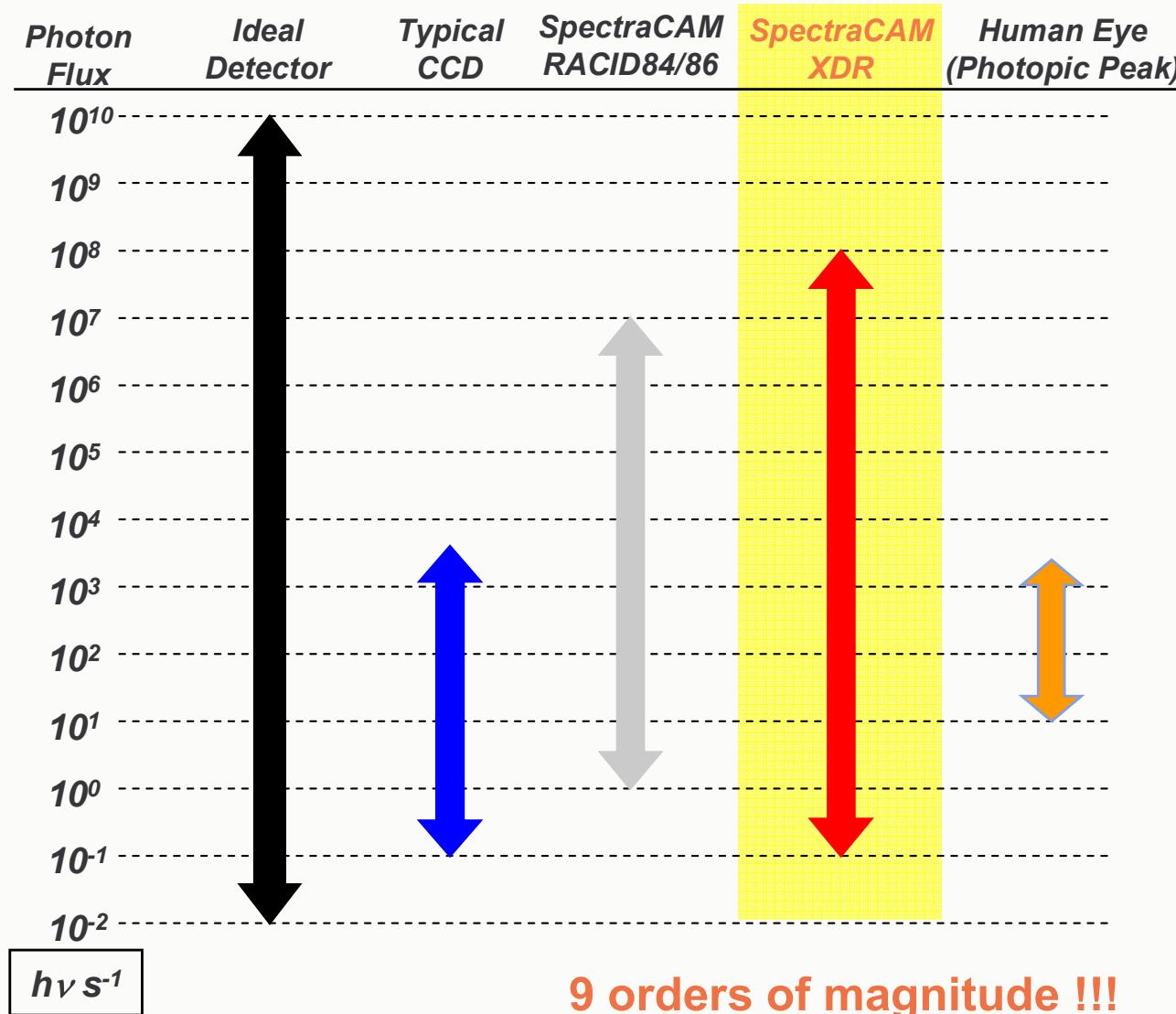
high-speed port 64-bit @ 120 MHz for data transfer

up to 9.600 full array mirror patterns / sec (7.6 Gbs)





# Dynamic Range of New System





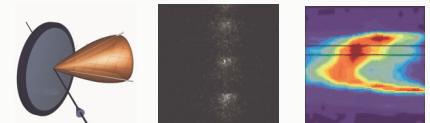
# Outline



**1. Transverse Beam Profiles**

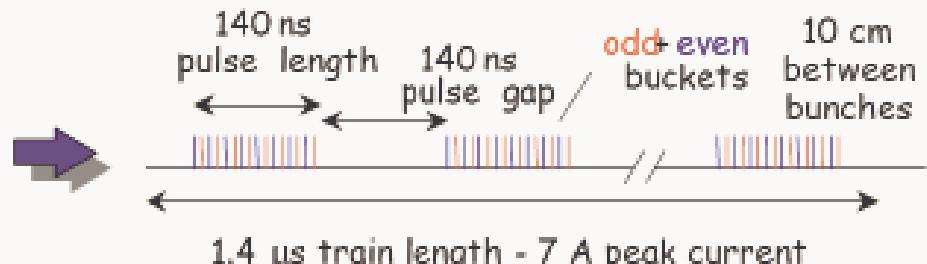
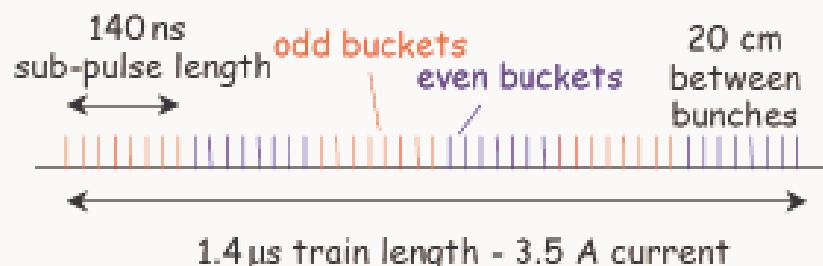
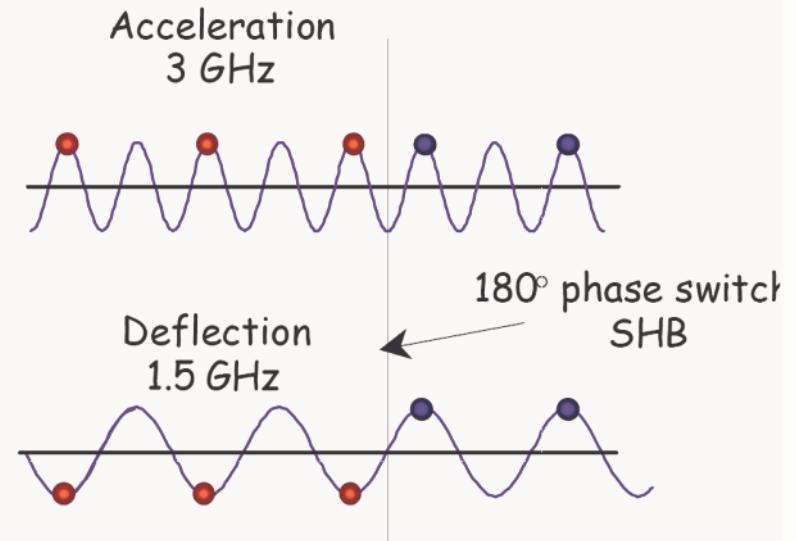
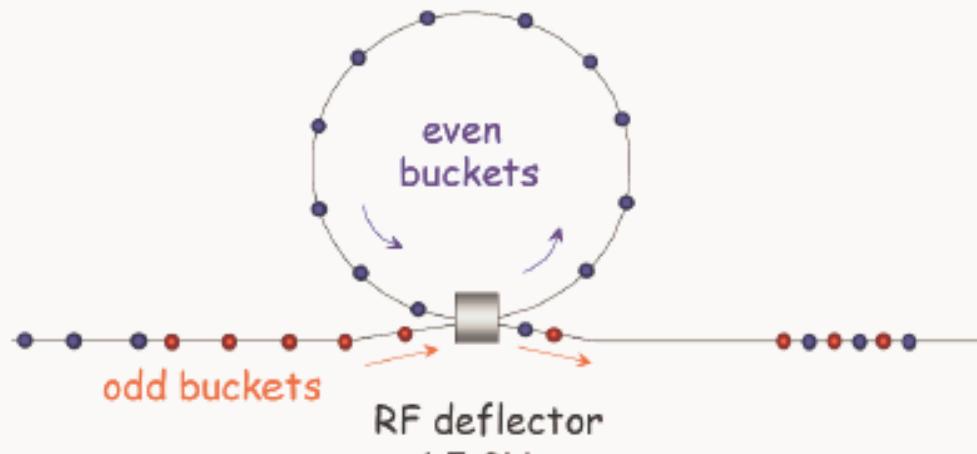
**2. Longitudinal Beam Profiles**

**3. Time-resolved Energy Measurements**



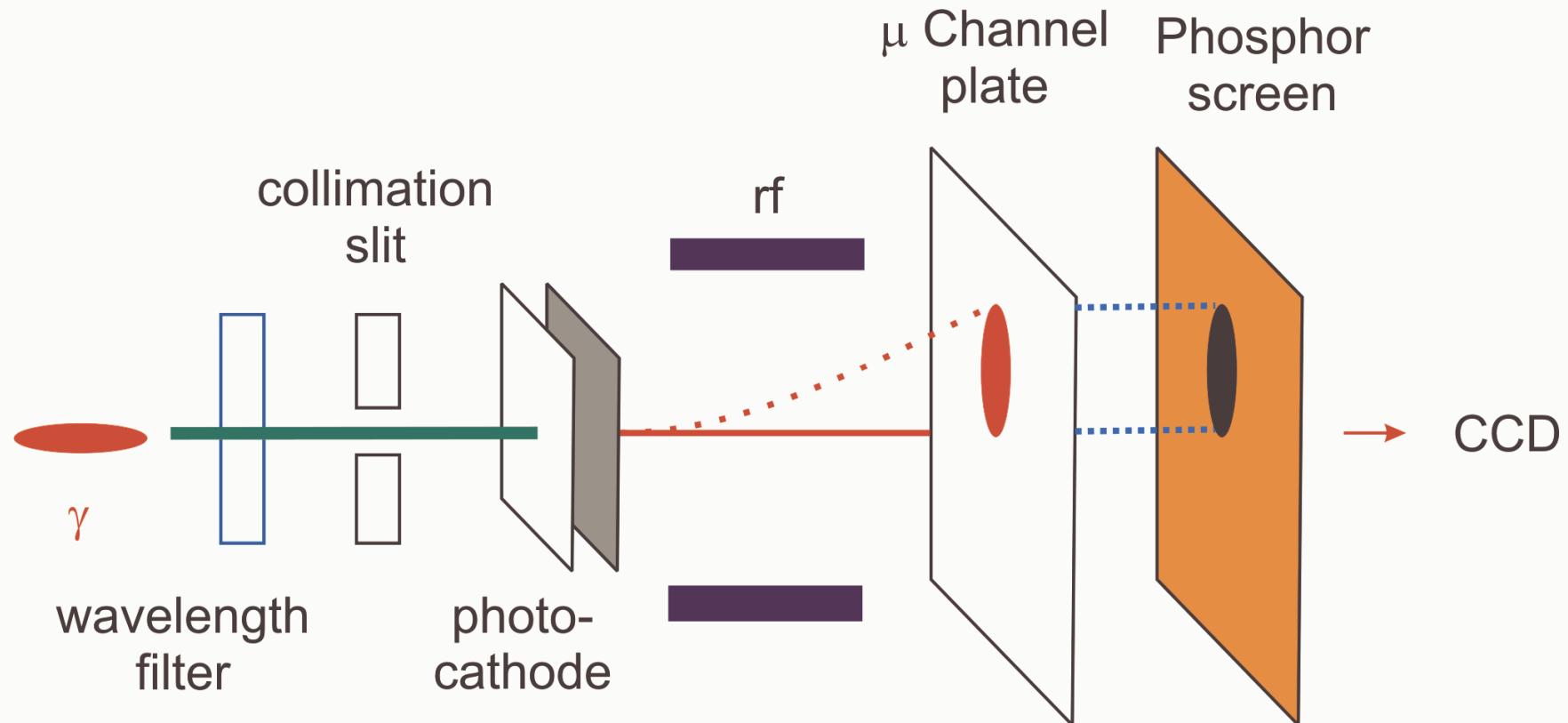


# Longitudinal Measurements



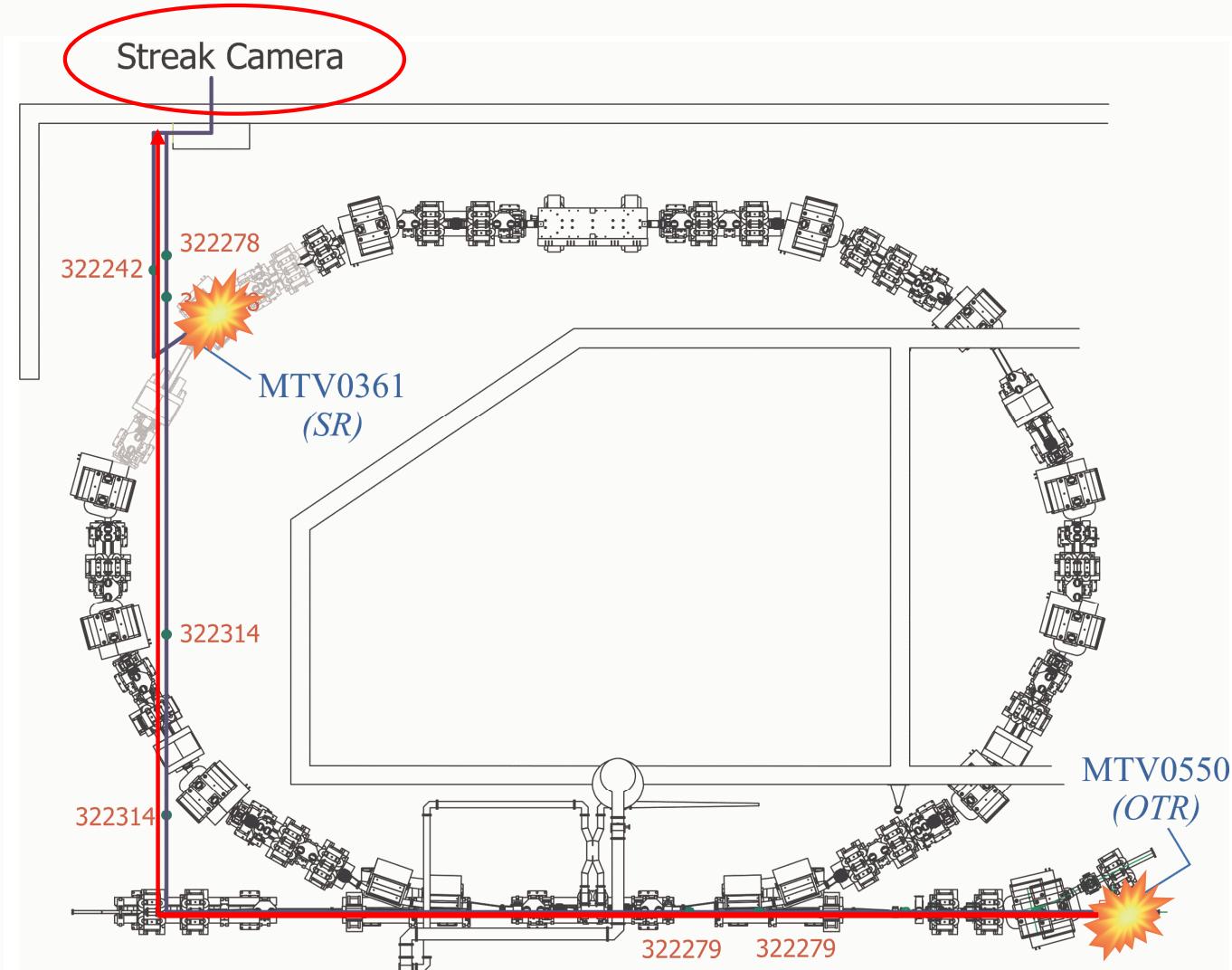


# Principle of a Streak Camera





# Long Optical Lines



CTF3 Note 072





# Design – Overview of Tasks



- Transmit the light using **telescopic** arrangements.
- Optimize between collecting, transmitting and demagnifying optics.
- Minimize the number of optical elements.
- Optimize optical resolution.

 **ZEMAX.**



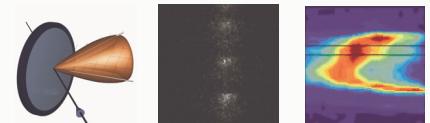


# Used for...



- Monitoring of phase switch using sub-harmonic bunchers
- Monitoring of the RF bunch combination
- Monitoring of track length modification with a wiggler
- Bunch length measurements  
*(compare to rf pickup)*

J. of Instr. **1** P09002 (2006)  
CLIC-Note 681





# Limitations

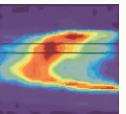
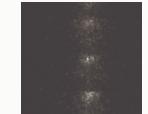


- Both, light intensity and aberrations at limit.
- Even longer lines (CR) no feasible option with present layout.

- Test with **optical fiber** not successful.  
Will now be used as Cherenkov detector.

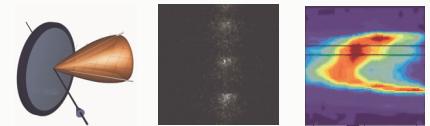
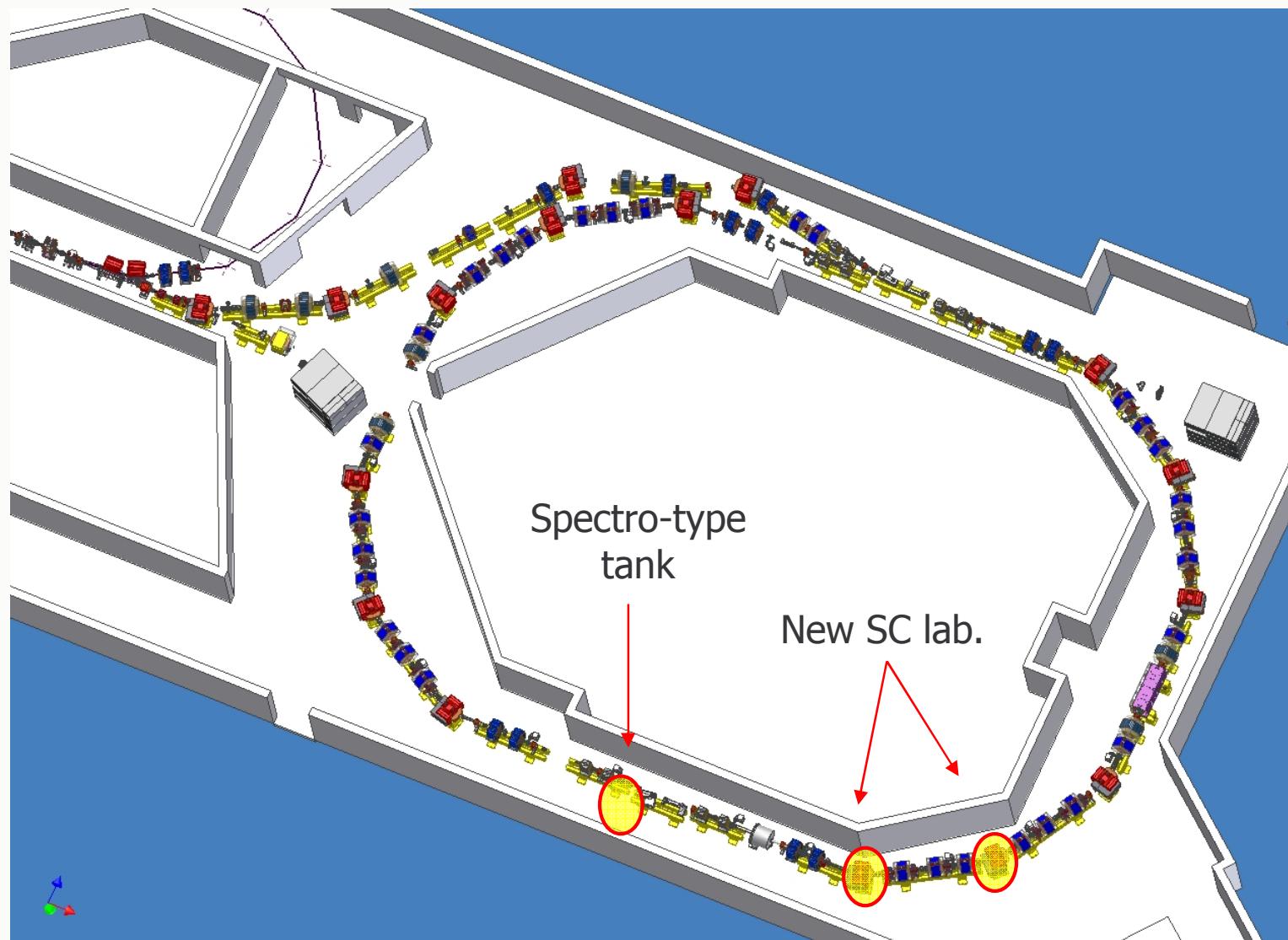
Second SC lab in 2012.

Building,...not year !





# Outlook: 2007





# Outline



1. Transverse Beam Profiles

2. Longitudinal Beam Profiles

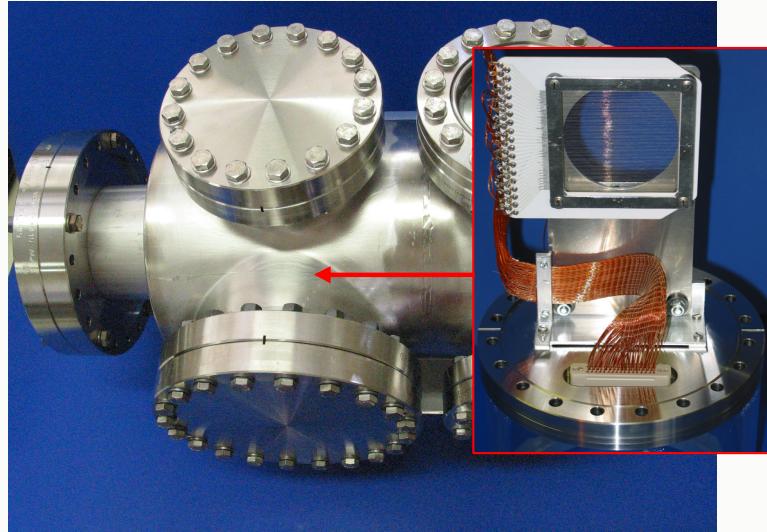
3. Time-resolved Energy Measurements



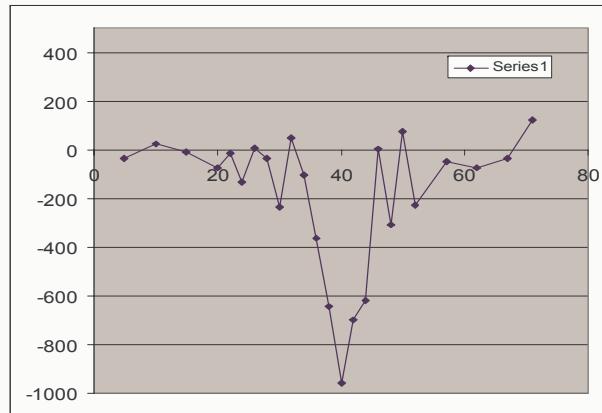
# Time Resolved Measurements



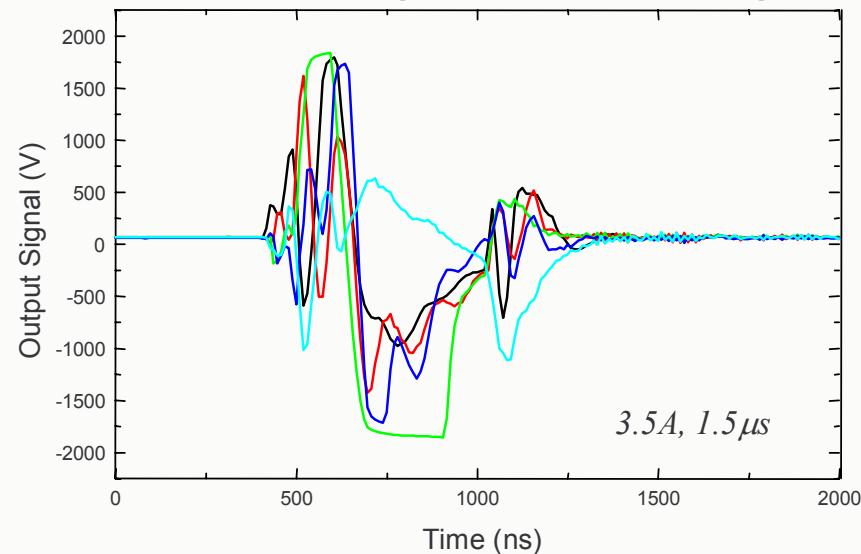
In 2003: SEM-Grids (two were installed), 2004 with modifications.



SEMgrid profiles  
~ 1 A – 320 ns – 25.5 MeV



Problems at higher beam charges

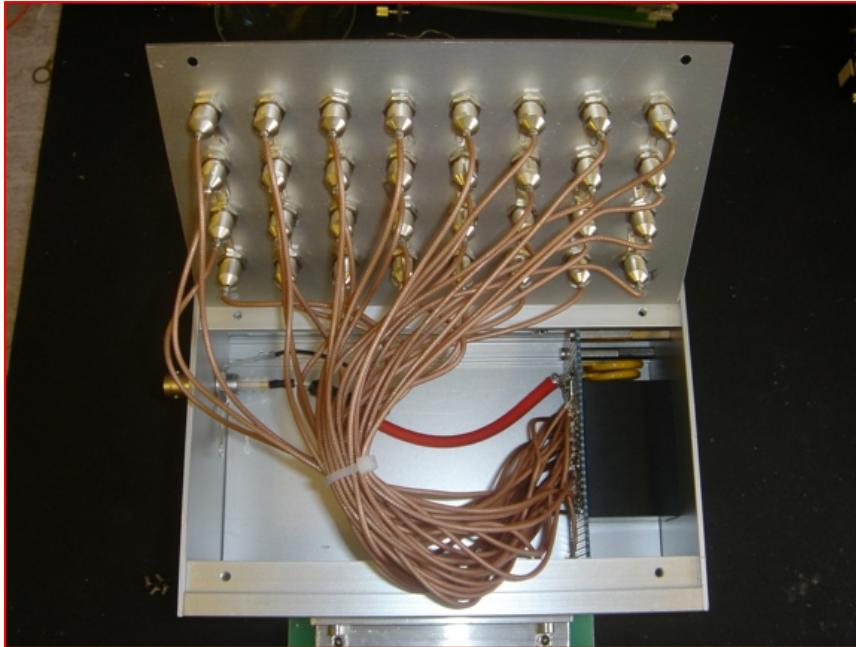


Method abandoned.



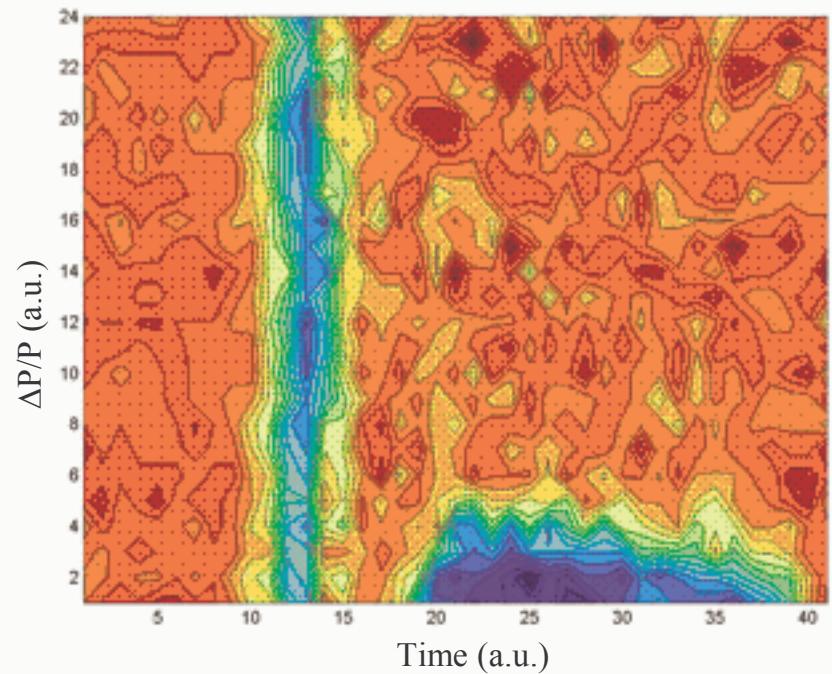


# Time Resolved Measurements



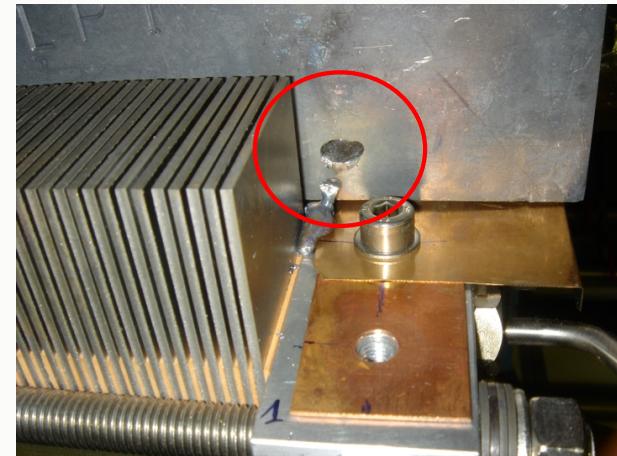
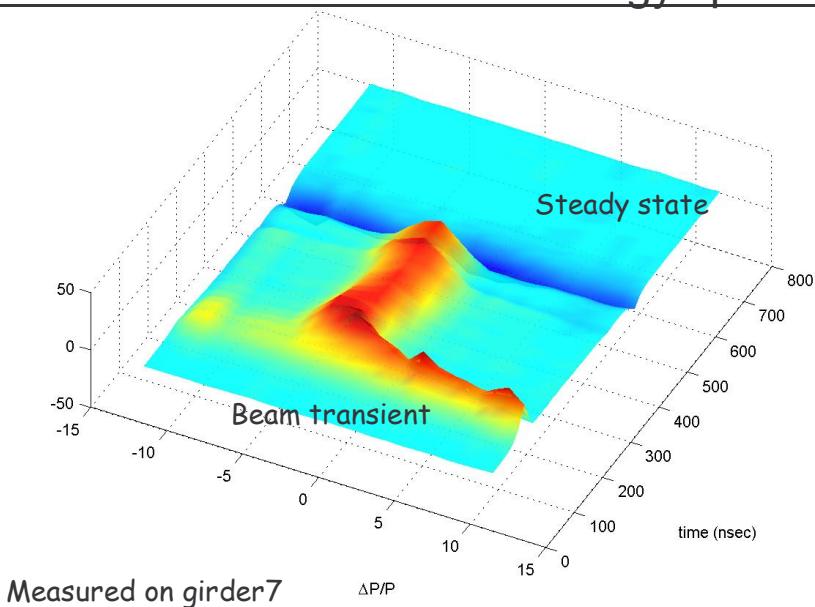
- Good time resolution [ns]
- Amplified to get good s/n ratio
- Screen quality / optics acceptance

- 32 channel segmented PMT from Hamamatsu Corp.
- OTR light from Al screen
- Use beam splitter



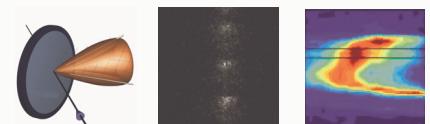
# Seg. Dump: $\Delta p/p$ (t)

Time evolution of the beam energy spread

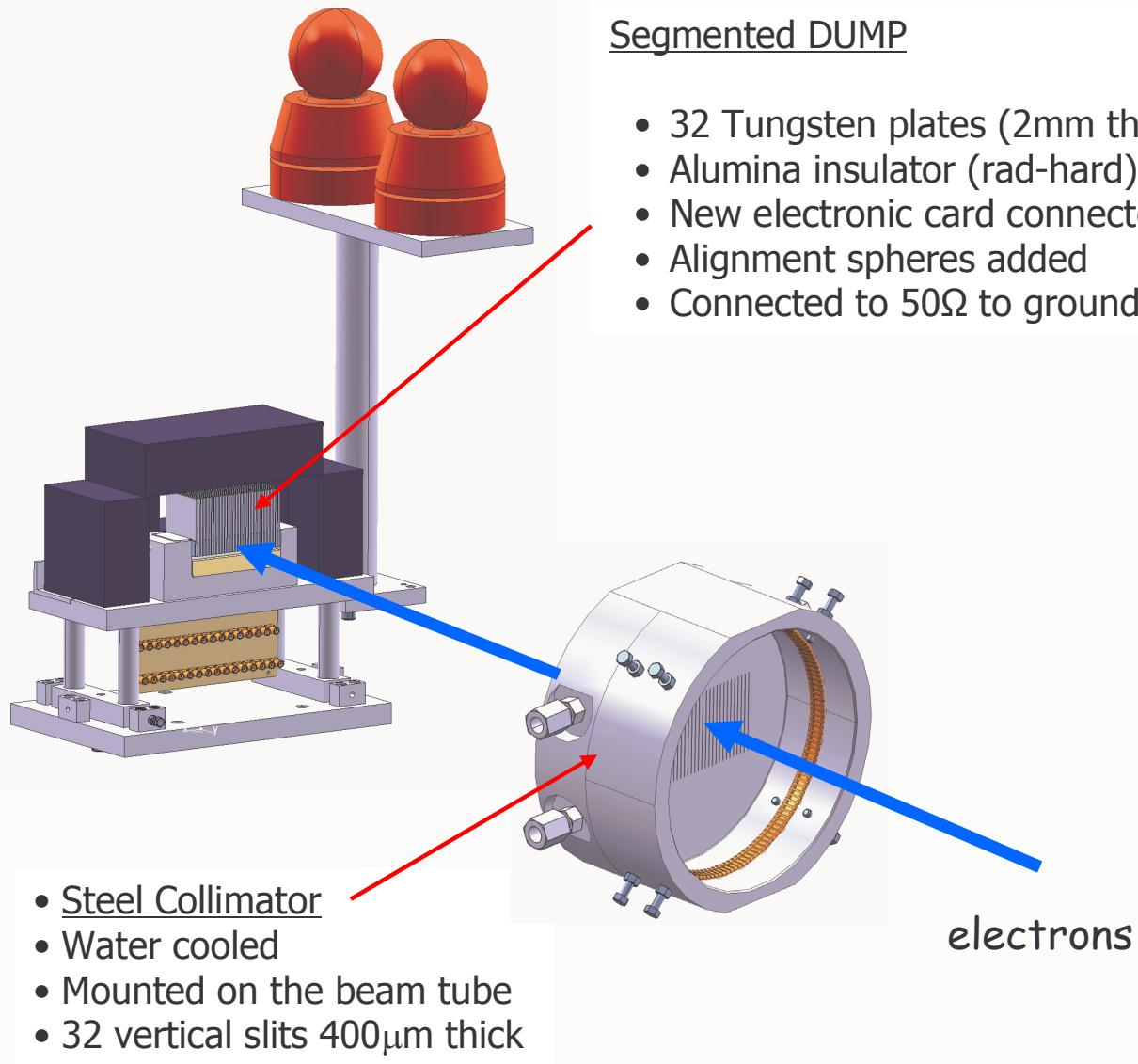


Bandwidth limited (parasitic noise)  
Destructive method (long term reliability)  
Non-radiation hard insulator

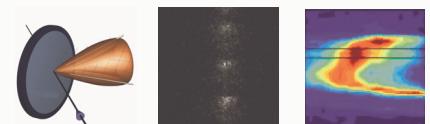
T. Lefevre



# Seg. Dump: New Layout



T. Lefevre

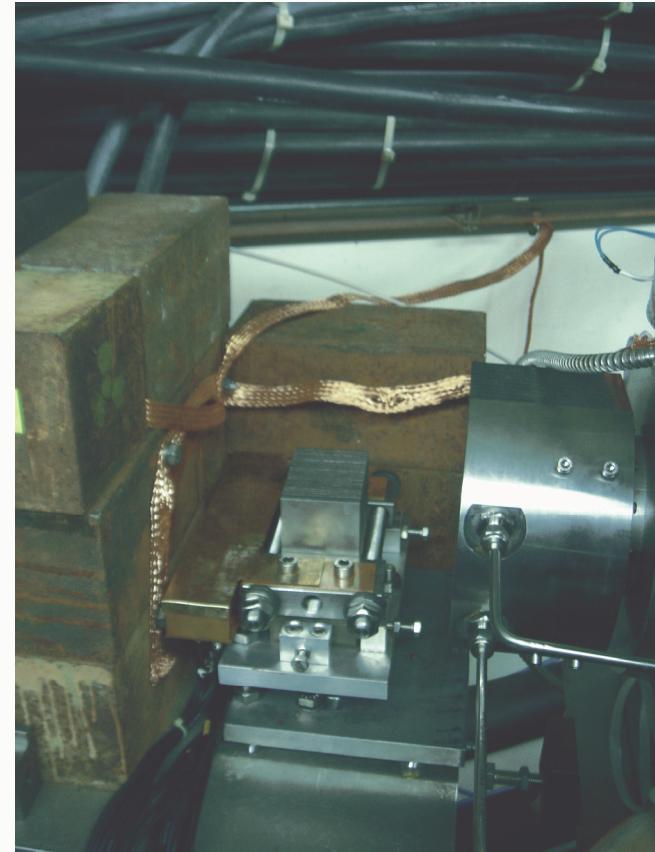




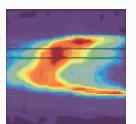
# Seg. Dump: New Installation, G. 4



Ready for this run.



T. Lefevre





# Conclusion



- Transverse profile monitors can be designed for a wide range of specifications,
- Beam halo monitoring showed promising results,
- Streak camera proved powerful tool for longitudinal beam profile measurements,
- Segmented monitors in spectrometer lines now finalized.

